



# An introduction to Monte Carlo methods in XRF analysis

Tom Schoonjans  
Joint ICTP-IAEA school, Trieste



# Outline

1. Introduction to Monte Carlo methods
2. Monte Carlo simulation of energy dispersive X-ray fluorescence (ED-XRF) spectrometers
3. Overview of available codes

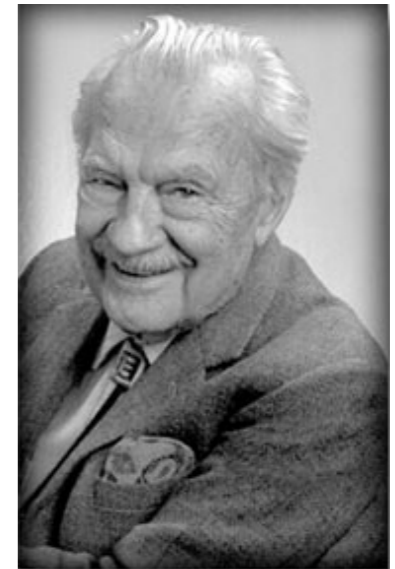
# Monte Carlo method: definition

*Refers to any technique of statistical sampling, employed to approximate solutions to quantitative problems which may be too complex to solve analytically*

# Origins of the Monte Carlo method

Developed twice independently

1. Enrico Fermi: moderation of neutrons
2. Metropolis, Ulam and Von Neumann: Manhattan project and ENIAC



*The beginning of the Monte Carlo method by N. Metropolis, 1987*

# Monte Carlo simulation method

- Widespread statistical simulation tool based on the use of random numbers
- A given problem is converted to its probabilistic analogue
- Used in mathematics, physics, engineering, biology, artificial intelligence, economy etc.

# Monte Carlo simulation method

- Phenomena occurring in the examined system must be characterized by probability density function (pdfs)
- Perform simulations by random sampling from the pdfs
- Desired result is taken as an average over a number of observations
- Engine is most often a pseudo random number generator

# Generating random variables with a specified distribution

- Continuous random variable:  $x_{min} \leq X \leq x_{max}$
- Probability density function:  $f(x) \geq 0$   
with:  $\int_{x_{min}}^{x_{max}} f(x)dx = 1$
- Cumulative distribution function:  $F(x) = \int_{x_{min}}^x f(u)du$
- Monotonously increasing,  $F(x_{min}) = 0, F(x_{max}) = 1$   
 $x = F^{-1}(R)$  inverse cdf, with  $0 \leq R \leq 1$

The values selected using the inverse cdf will reproduce the distribution  $f(x)$  in the interval  $[x_{min}, x_{max}]$

# Generating random variables with a specified distribution

- Discrete random variables:  $X = \{x_1, \dots, x_n\}$
- Corresponding probabilities of events  $\{x_1, \dots, x_n\}: \{P_1, \dots, P_n\}$   $\sum_{i=1}^n P_i = 1$
- $R$ : uniform random number in  $[0, 1]$
- Select event for index  $k = \{1, \dots, n\}$ :

$$\sum_{i=1}^{k-1} P_i < R \leq \sum_{i=1}^k P_i$$



# Random number generators

- Critical component of all Monte Carlo simulations!
- Initially performed using lists of “true” random numbers
- Von Neumann: first pseudo random number generator (middle-square method)
- Properties: speed, period length, uniformity, coverage

# Pseudo random number generators

## 1. Linear congruential generators

- Short period: maximum  $2^{32}$  or  $2^{64}$
- Easily implemented
- $X_{n+1} = (aX_n + b) \bmod m$

## 2. Mersenne twister

- Most commonly used PRNG nowadays
- Period:  $2^{19937} - 1$
- Passes the Diehard test package
- GPU implementation available (MTGP)

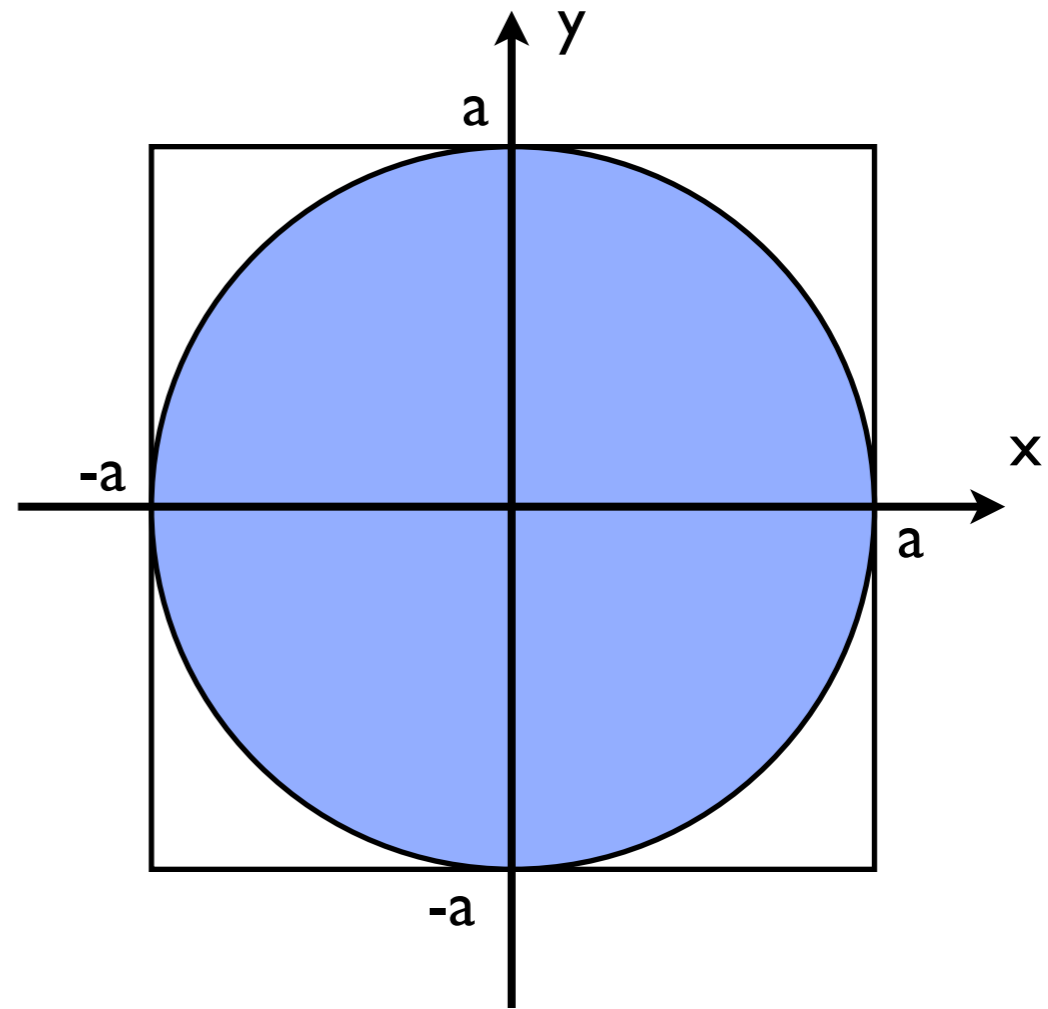
# Pseudo random number generators

## 3. `/dev/random`

- special device file on Unix(-like) operating systems
- very high quality randomness (for cryptographic applications!)
- entropy pool fed with noise produced by device drivers, network interfaces etc.
- blocks → slow!
- non-blocking version: `/dev/urandom` (Linux only)
- Windows alternative: `CryptGenRandom` and `rand_s`

# Example: estimation of $\pi$

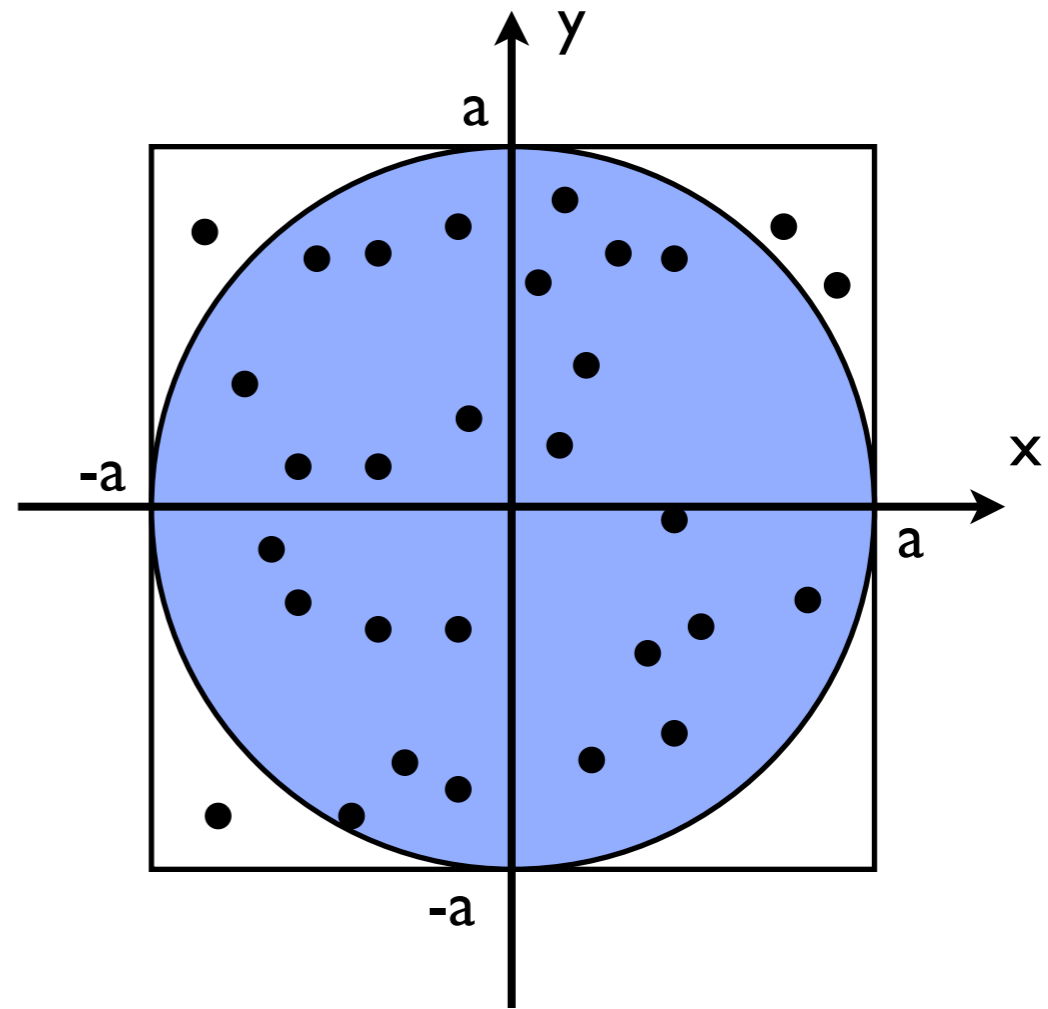
Random selection of points within a square of  $2a \times 2a = 4a^2$  area



$$\pi = 4 \left( \frac{a^2 \pi}{4a^2} \right) = 4 \left( \frac{A_{\text{circle}}}{A_{\text{square}}} \right) \approx 4 \left( \frac{N_{\text{circle}}}{N_{\text{total}}} \right)$$

# Example: estimation of $\pi$

Random selection of points within a square of  $2a \times 2a = 4a^2$  area



$$\pi = 4 \left( \frac{a^2 \pi}{4a^2} \right) = 4 \left( \frac{A_{\text{circle}}}{A_{\text{square}}} \right) \approx 4 \left( \frac{N_{\text{circle}}}{N_{\text{total}}} \right)$$

# Monte Carlo simulation of X-ray fluorescence spectrometers

# Brute force algorithm

# A general Monte Carlo simulation of ED-XRF spectrometers

- Basic idea: predict the response of X-ray imaging and spectroscopy experiments
- Optimize and design experimental setups *in silico*
- Dose calculation
- Estimation of detection limits
- Quantification



# A general Monte Carlo simulation of ED-XRF spectrometers

- Simulates the fate of individual photons
- Trajectories are modeled as consisting of a number of straight steps.
- At the end of each step, an interaction will occur, leading to a change in direction and energy



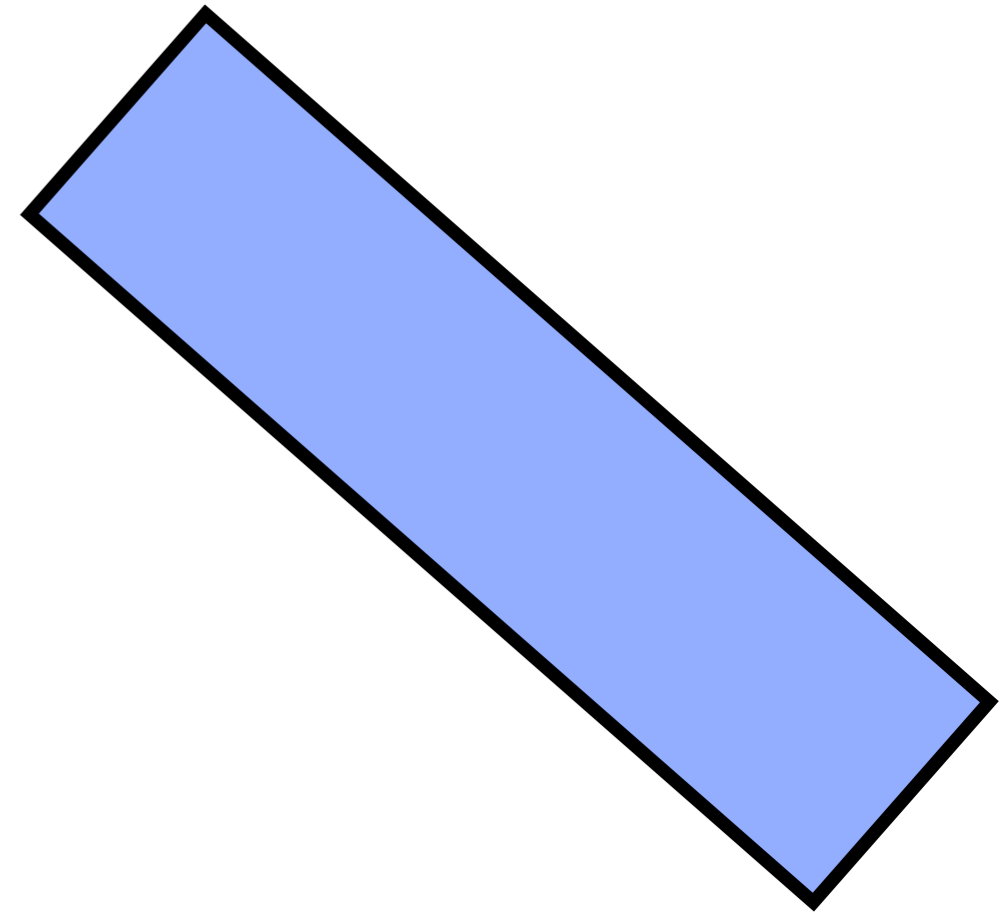


## Initial photon properties:

- Energy
- Degree of linear polarization
- Intensity (weight)
- Point or Gaussian source
- Discrete or continuous

## Sample properties:

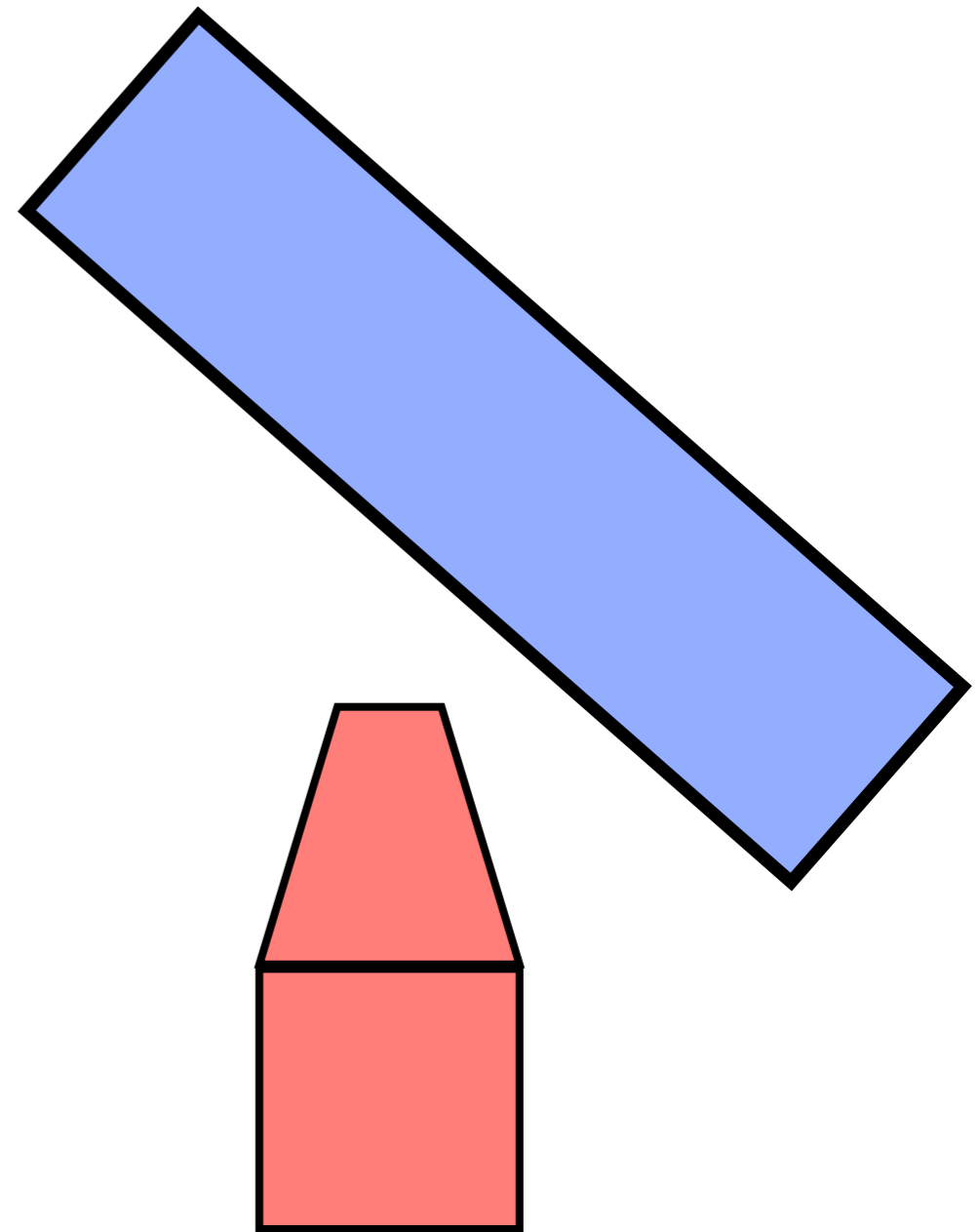
- position and orientation
- $n$  parallel layers
- Thickness
- Density
- Composition



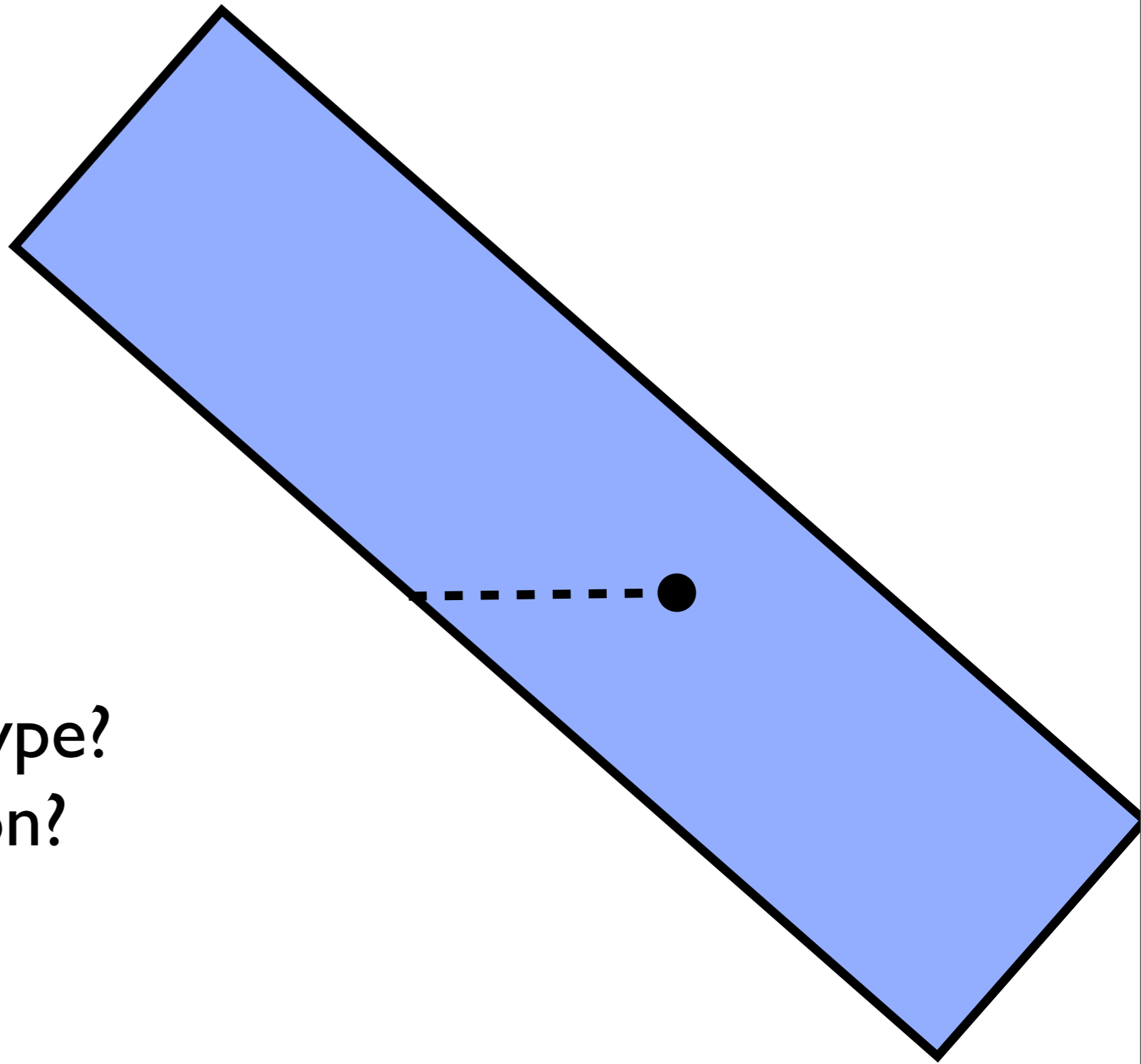


## Detector properties:

- position and orientation
- crystal
- window
- zero/gain
- Collimator (optional)



Stepsize?  
Atom type?  
Interaction type?  
New direction?



# Selection of the step length

- Determined by the density, thickness and the absorption coefficients of the sample layers
- Inverse cdf is based on the Bouguer-Lambert-Beer equation:

$$f(x) = \mu\rho \exp(-\mu\rho x)$$

$$F(x) = \int_0^x \mu\rho \exp(-\mu\rho t) dt = 1 - \exp(-\mu\rho x) \equiv R \Rightarrow x = -\frac{1}{\mu\rho} \ln(1 - R) \Leftrightarrow x = -\frac{1}{\mu\rho} \ln(R)$$

# Selection of atom type

Current layer contains  $n_e$  different elements,  
each element present with a weight fraction  $w_i$

$$\sum_{i=0}^k w_i m_i \leq R < \sum_{i=0}^{k+1} w_i m_i \quad \text{with} \quad m_i = \frac{\mu_i}{\sum_{i=0}^{n_e} w_i \mu_i}$$



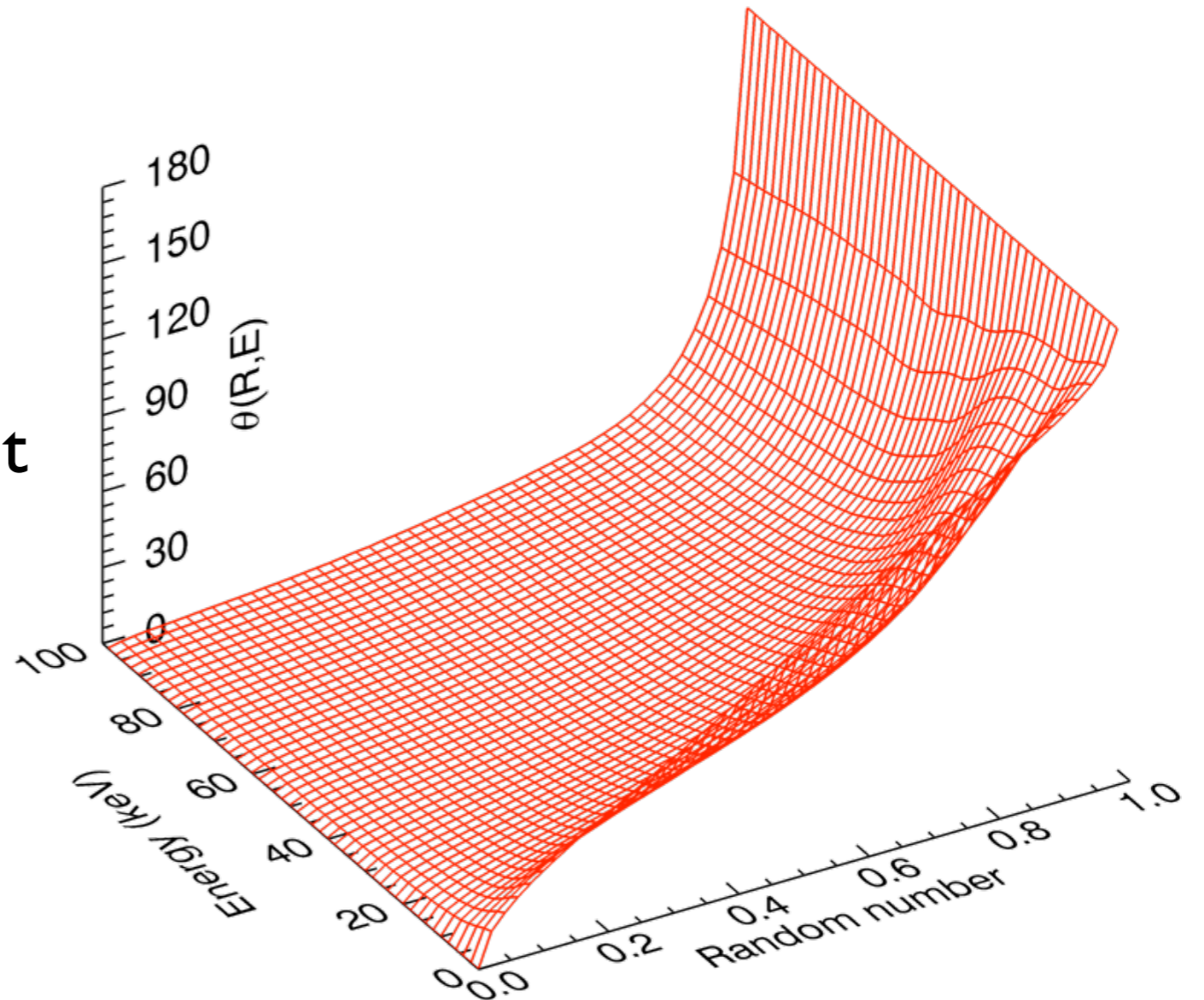
# Selection of interaction type

Three possibilities:

1. Rayleigh scattering:  $0 \leq R \leq \frac{\sigma_{RZ}}{\mu_Z}$
2. Compton scattering:  $\frac{\sigma_{RZ}}{\mu_Z} < R \leq \frac{\sigma_{RZ} + \sigma_{CZ}}{\mu_Z}$
3. Photoelectric effect:  $\frac{\sigma_{RZ} + \sigma_{CZ}}{\mu_Z} < R \leq 1$

# Rayleigh scattering

- Energy remains unchanged
- Scattering angle  $\theta_i$  and azimuthal angle  $\varphi_i$  must be selected in accordance with the appropriate differential Rayleigh cross section.
- Inverse CDFs are calculated numerically

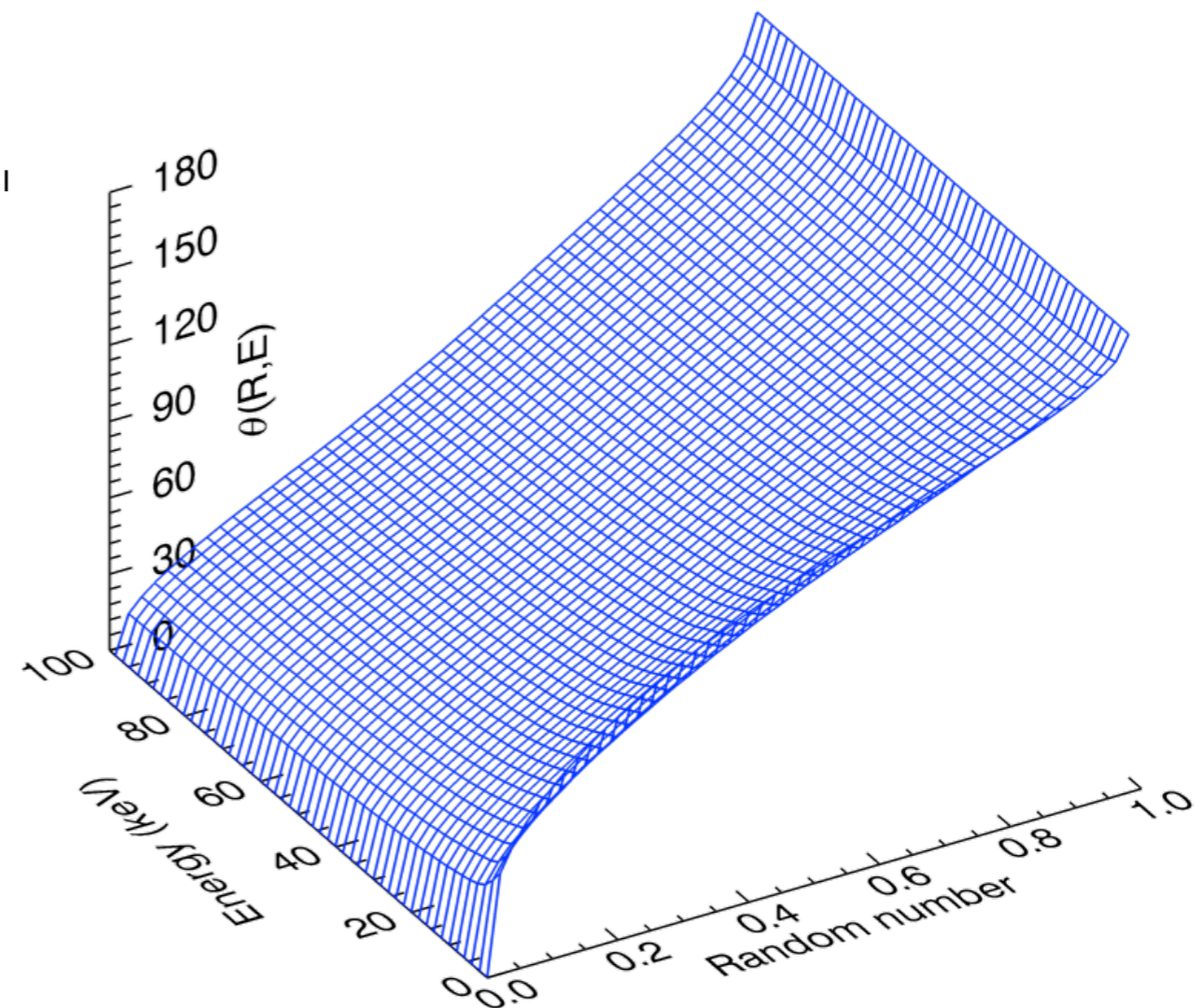


# Compton scattering

- Energy-loss according to Compton formula:

$$E_{i+1} = E_i \left( 1 + \frac{E_i}{m_e c^2} (1 - \cos \theta_i) - \frac{2p_z}{m_e c} \sin \frac{\theta_i}{2} \right)^{-1}$$

- Scattering angle  $\theta_i$  and azimuthal angle  $\varphi_i$  must be selected in accordance with the appropriate differential Compton cross section.
- Takes into account the influence of the momentum  $p_z$  of the scattering electron on the energy-transfer



# Photoelectric effect

Which shell experienced effect?

$$\text{shell} = \left\{ \begin{array}{l} \text{K shell: } 0 \leq R < \frac{\tau_K}{\tau} \\ \text{L1 shell: } \frac{\tau_K}{\tau} \leq R < \frac{\tau_K + \tau_{L1}}{\tau} \\ \text{L2 shell: } \frac{\tau_K + \tau_{L1}}{\tau} \leq R < \frac{\tau_K + \tau_{L1} + \tau_{L2}}{\tau} \\ \text{L3 shell: } \frac{\tau_K + \tau_{L1} + \tau_{L2}}{\tau} \leq R < \frac{\tau_K + \tau_{L1} + \tau_{L2} + \tau_{L3}}{\tau} \\ \dots \end{array} \right.$$

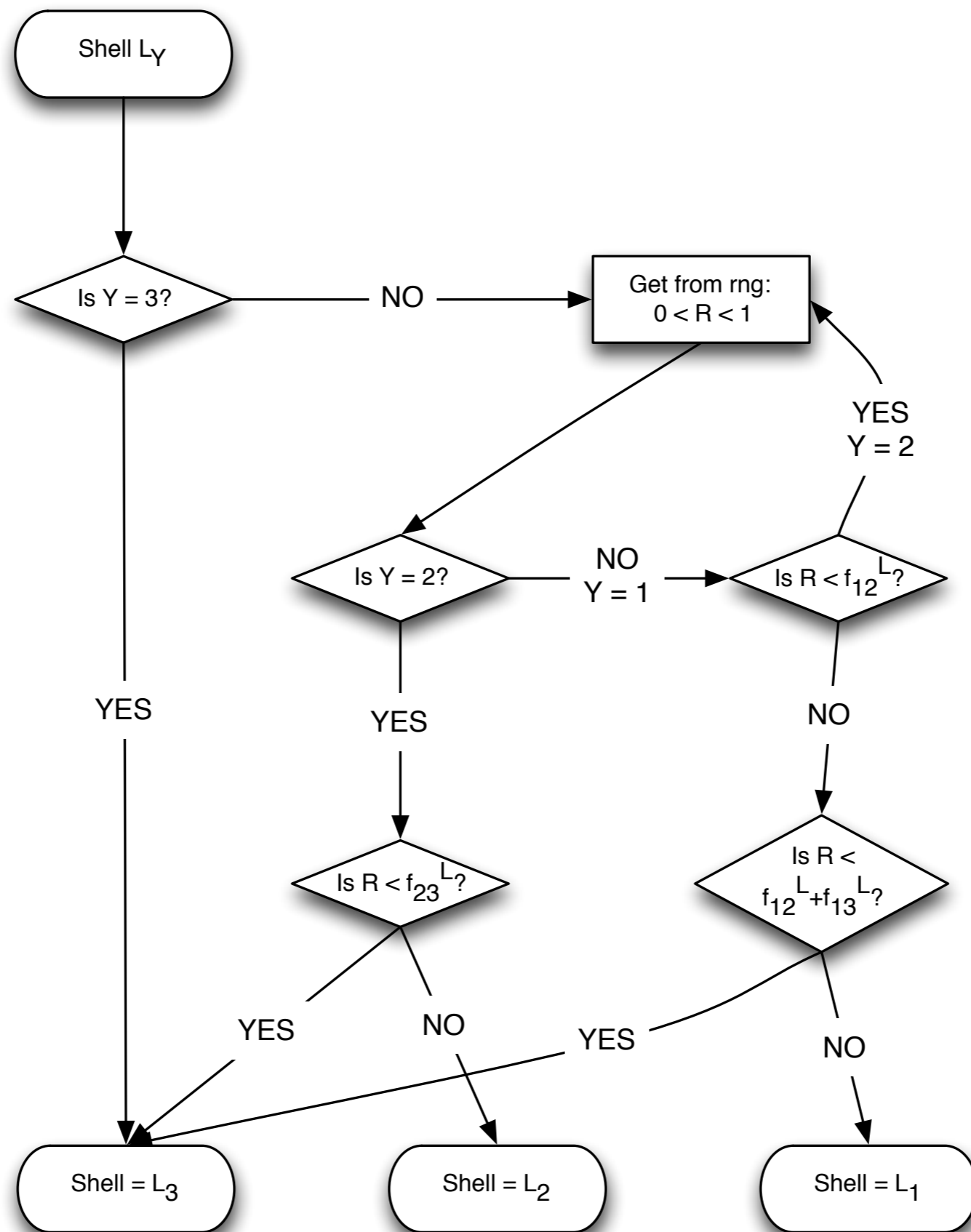
# Photoelectric effect

Fluorescence yield: fluorescence or Auger effect?

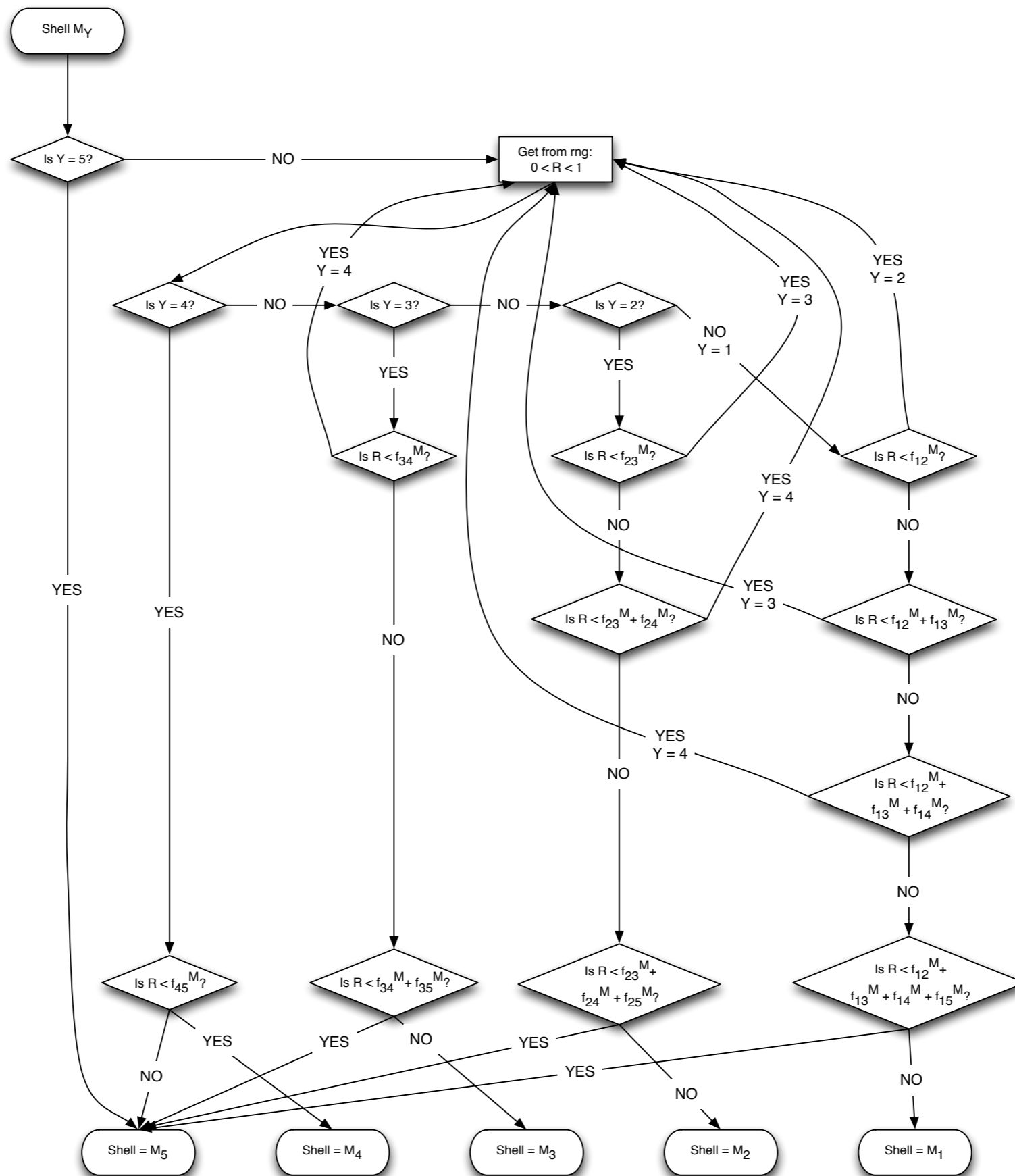
Using yields for *primary* vacancies!

Fluorescence if:  $0 \leq R < \omega_{\text{shell}}$

Take into account Coster-Kronig transitions!



**Definitive selection of L-shell  
to be involved in transition**



**Definitive selection of M-shell  
to be involved in transition**

# Photoelectric effect

Which fluorescence line?

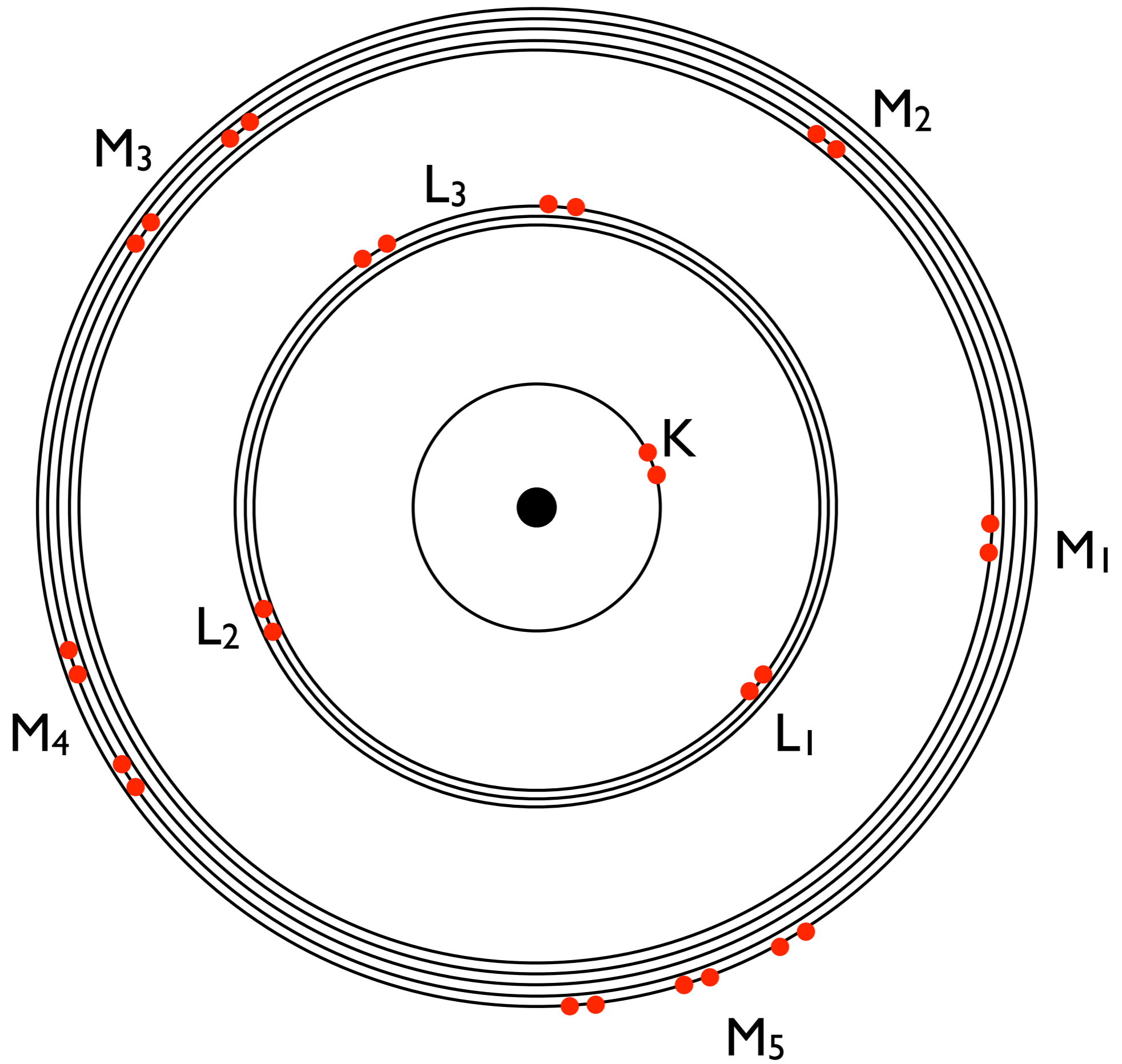
Determine using the shell's radiative rates:

$$\text{line} = \left\{ \begin{array}{l} KL_2 \text{ line: } 0 \leq R < p_{KL_2} \\ KL_3 \text{ line: } p_{KL_2} \leq R < p_{KL_2} + p_{KL_3} \\ KM_2 \text{ line: } p_{KL_2} + p_{KL_3} \leq R < p_{KL_2} + p_{KL_3} + p_{KM_2} \\ KM_3 \text{ line: } p_{KL_2} + p_{KL_3} + p_{KM_2} \leq R < p_{KL_2} + p_{KL_3} + p_{KM_2} + p_{KM_3} \\ \dots \end{array} \right.$$

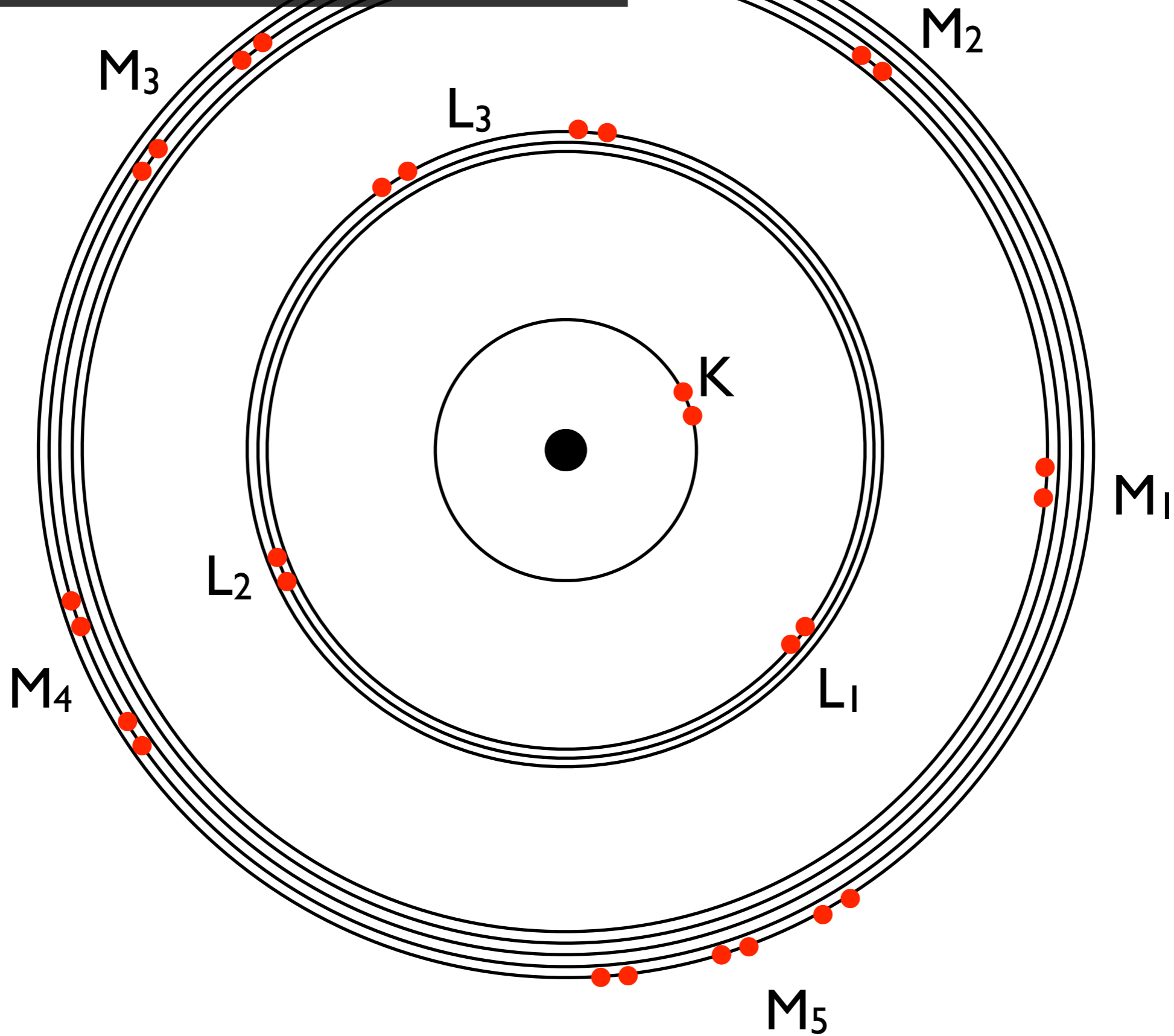
Scattering angle  $\theta_i$  and azimuthal angle  $\varphi_i$  are chosen random:  $\cos \theta_i = (2R - 1)$

$$\varphi_i = 2\pi R$$

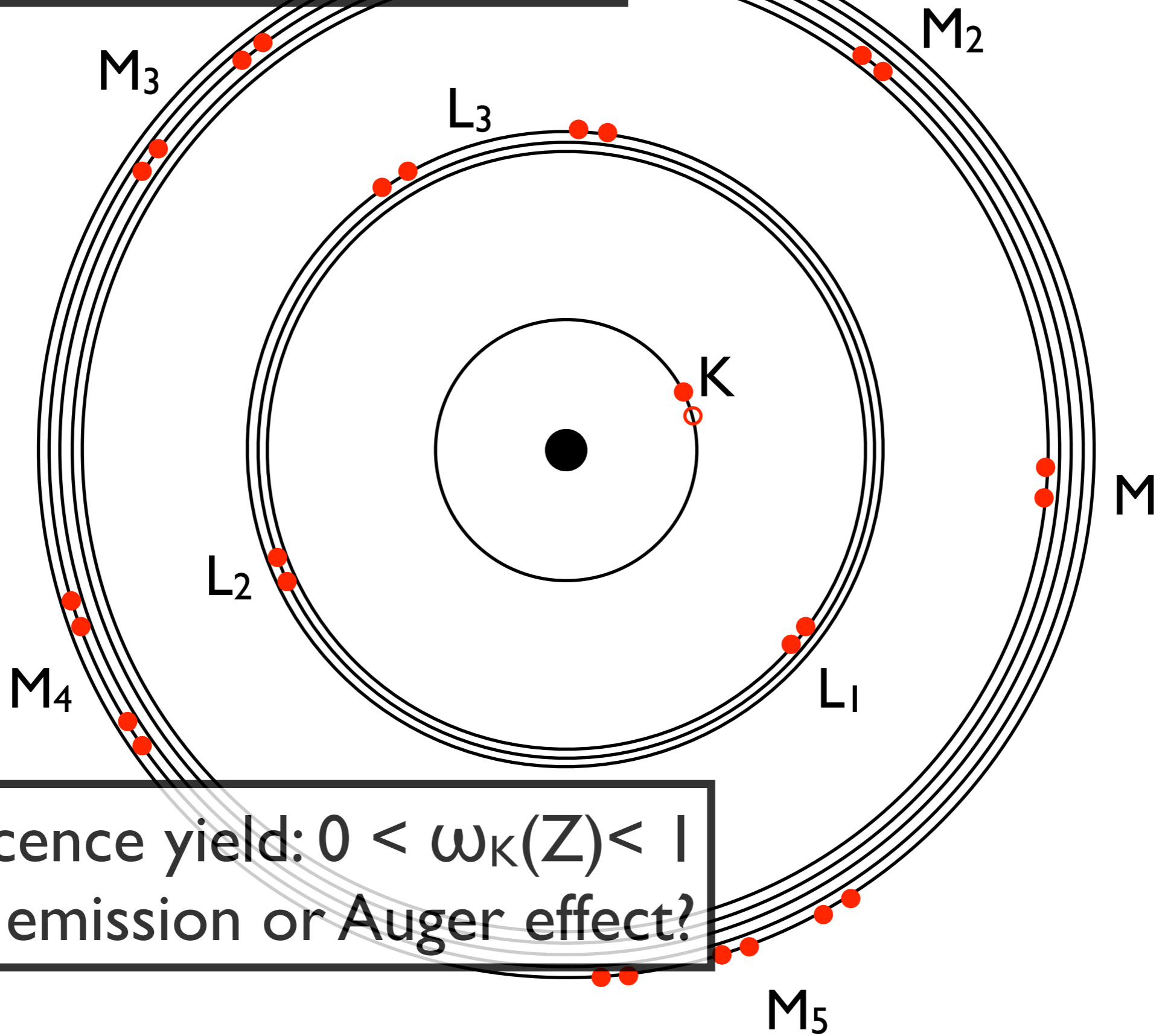




# Photoelectric effect: K shell

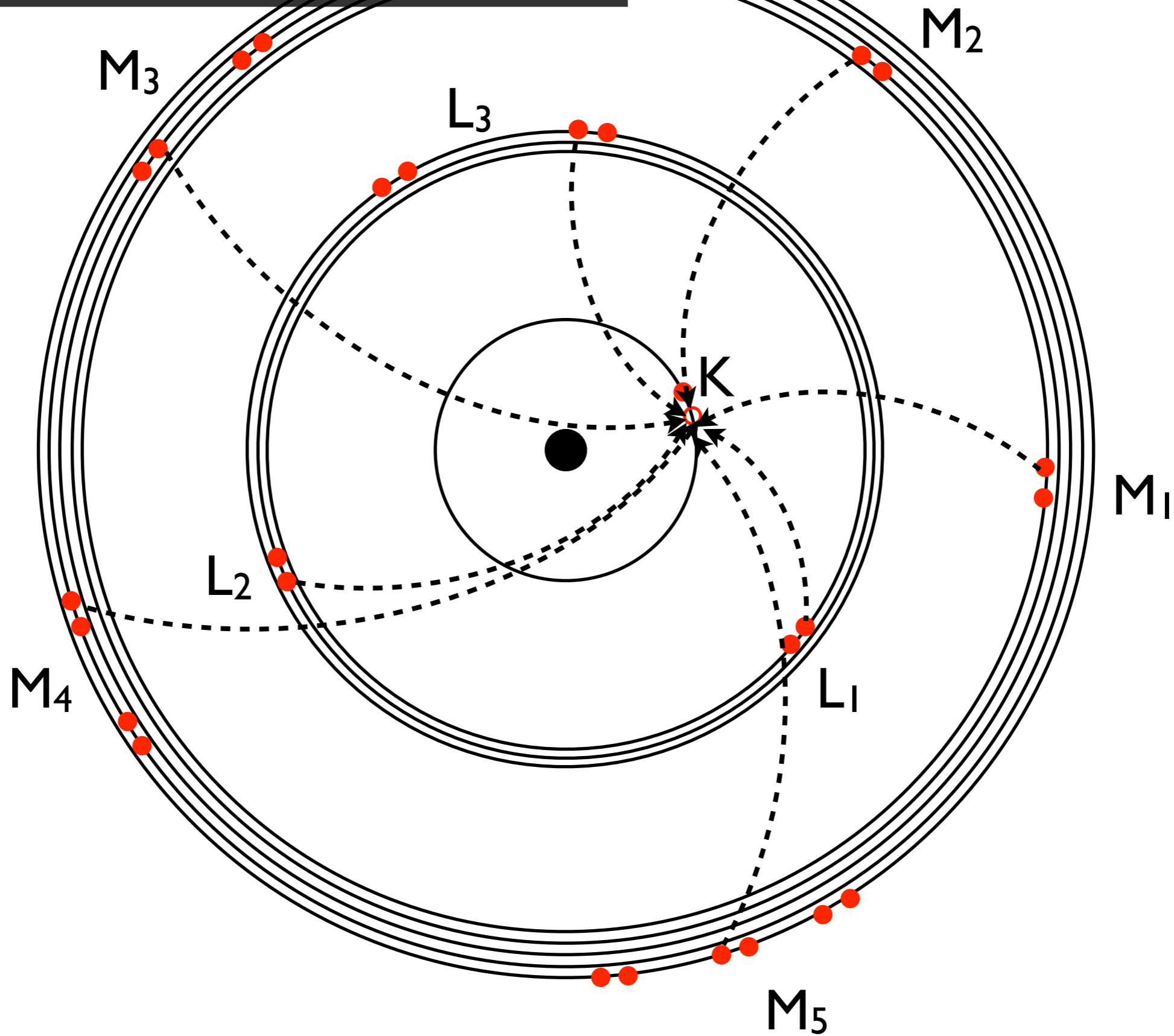


# Photoelectric effect: K shell

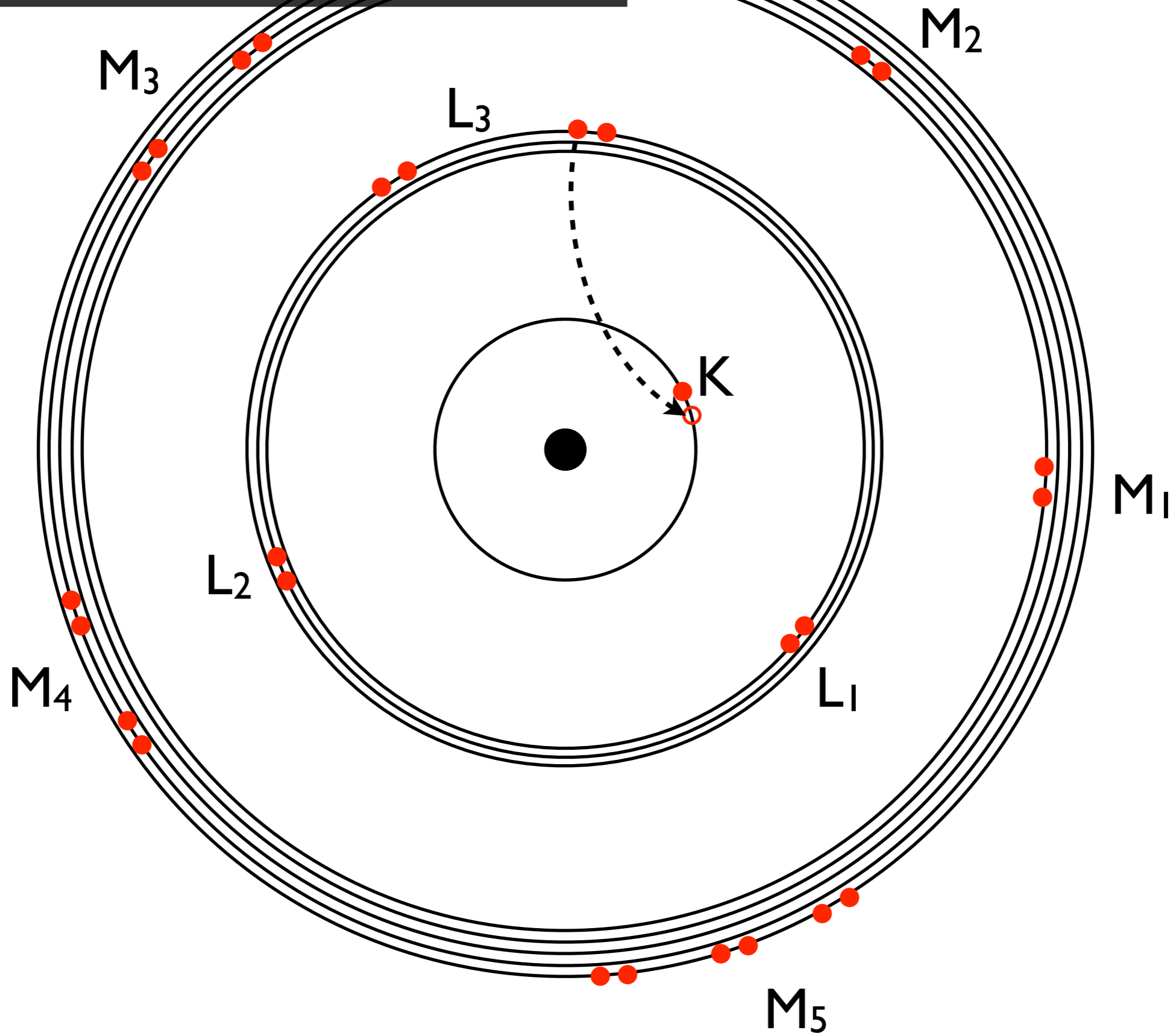


Fluorescence yield:  $0 < \omega_K(Z) < 1$   
Photon emission or Auger effect?

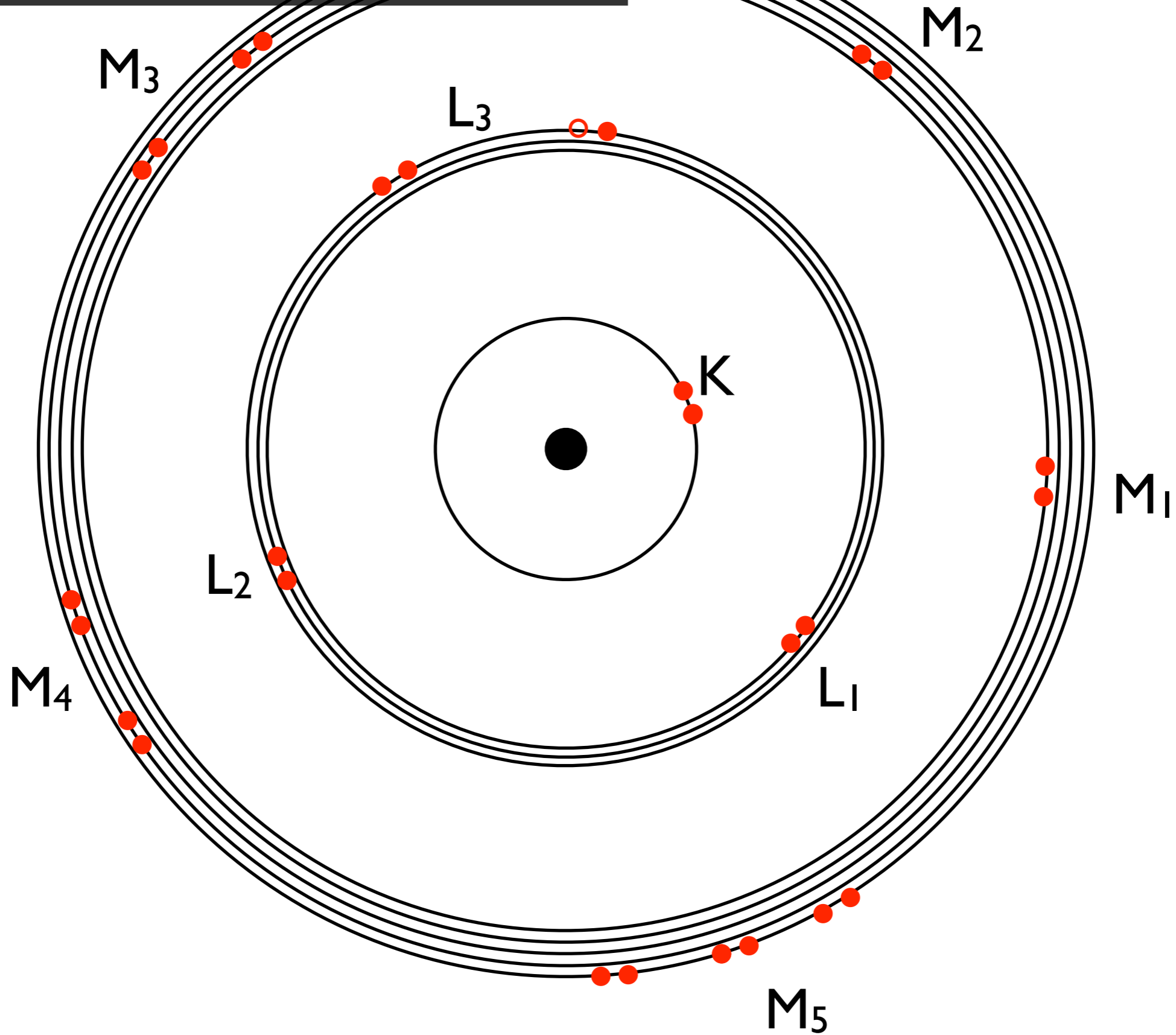
# Photoelectric effect: K shell



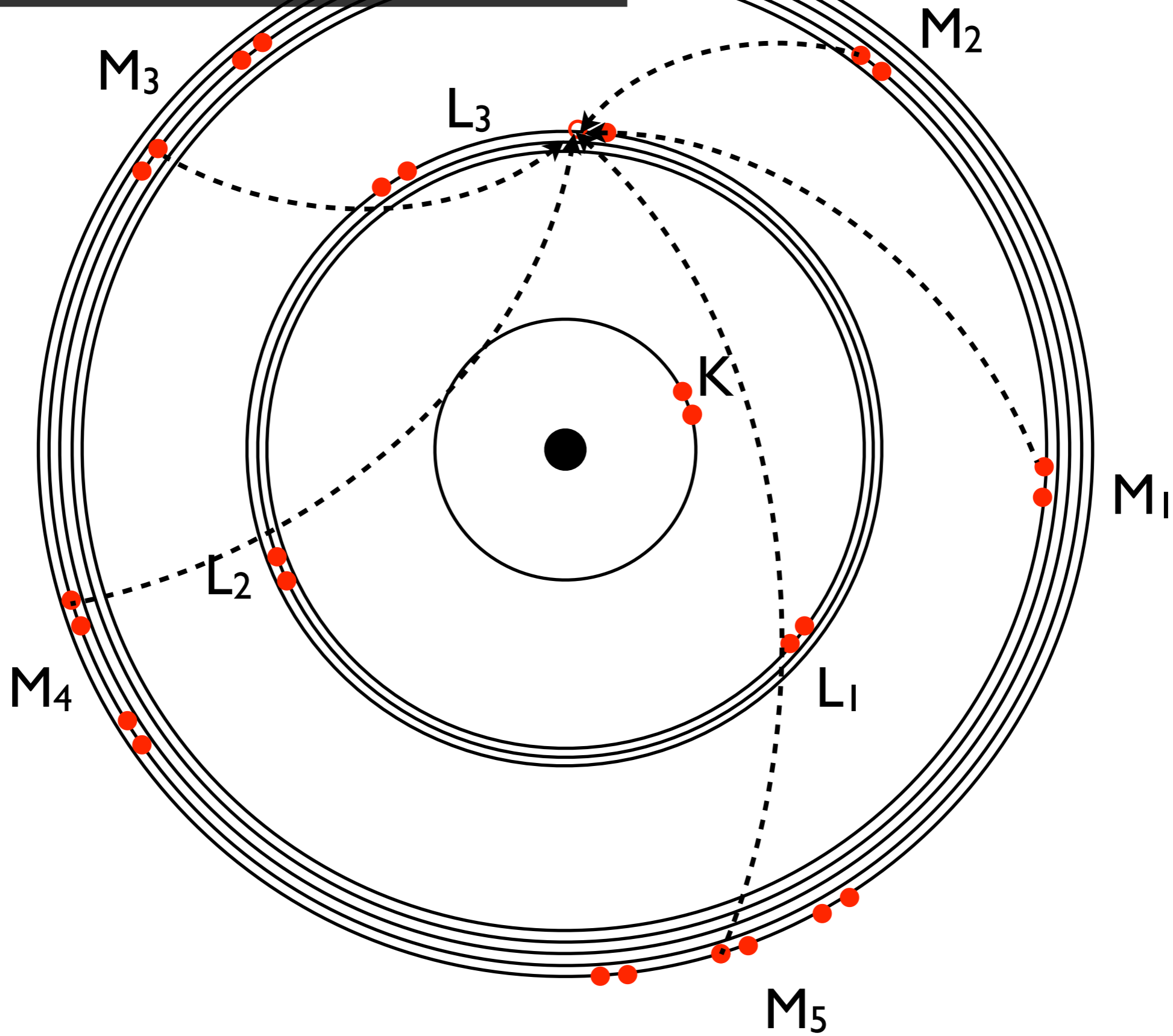
# Photoelectric effect: K shell



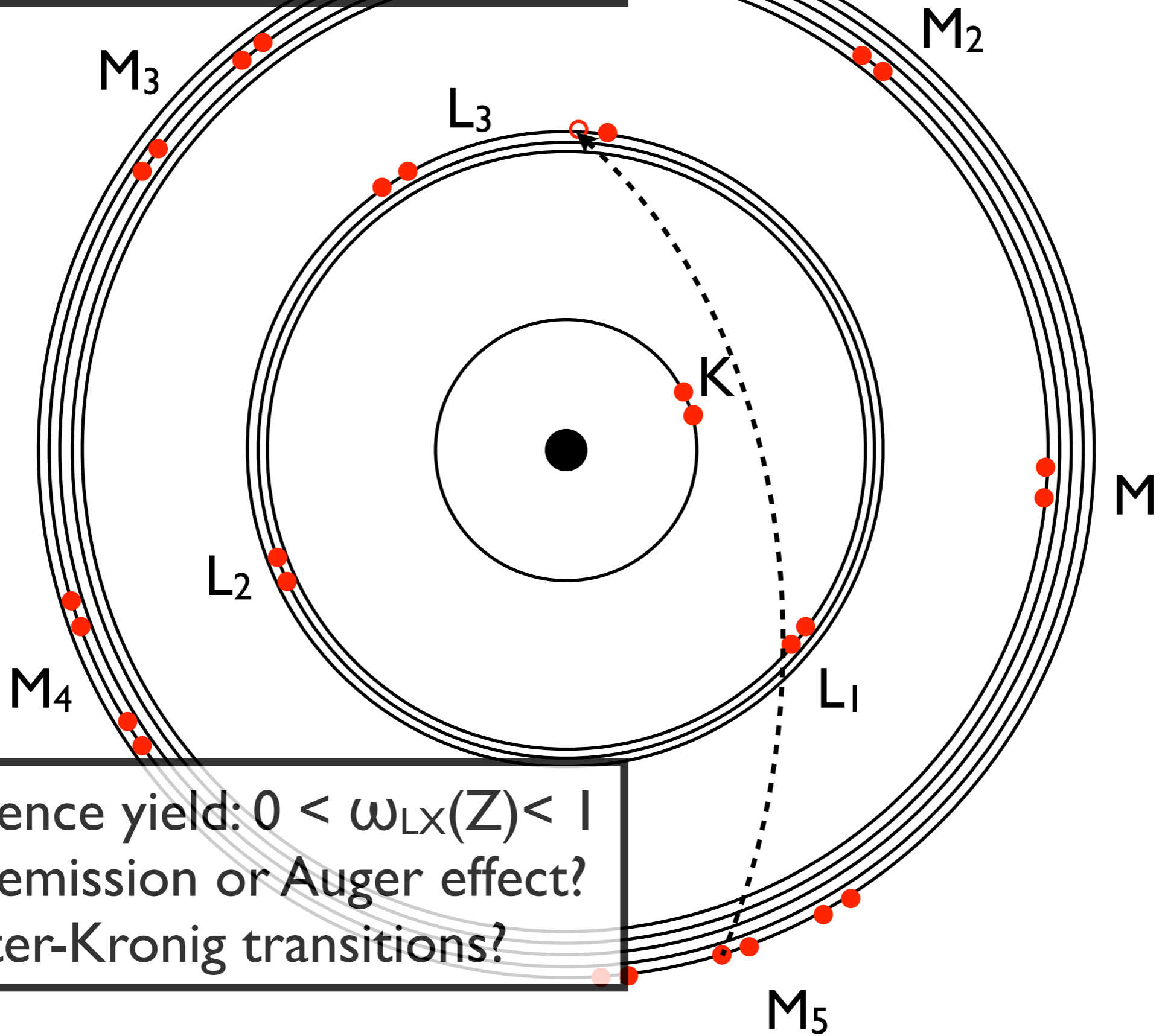
# Photoelectric effect: K shell



# Photoelectric effect: K shell



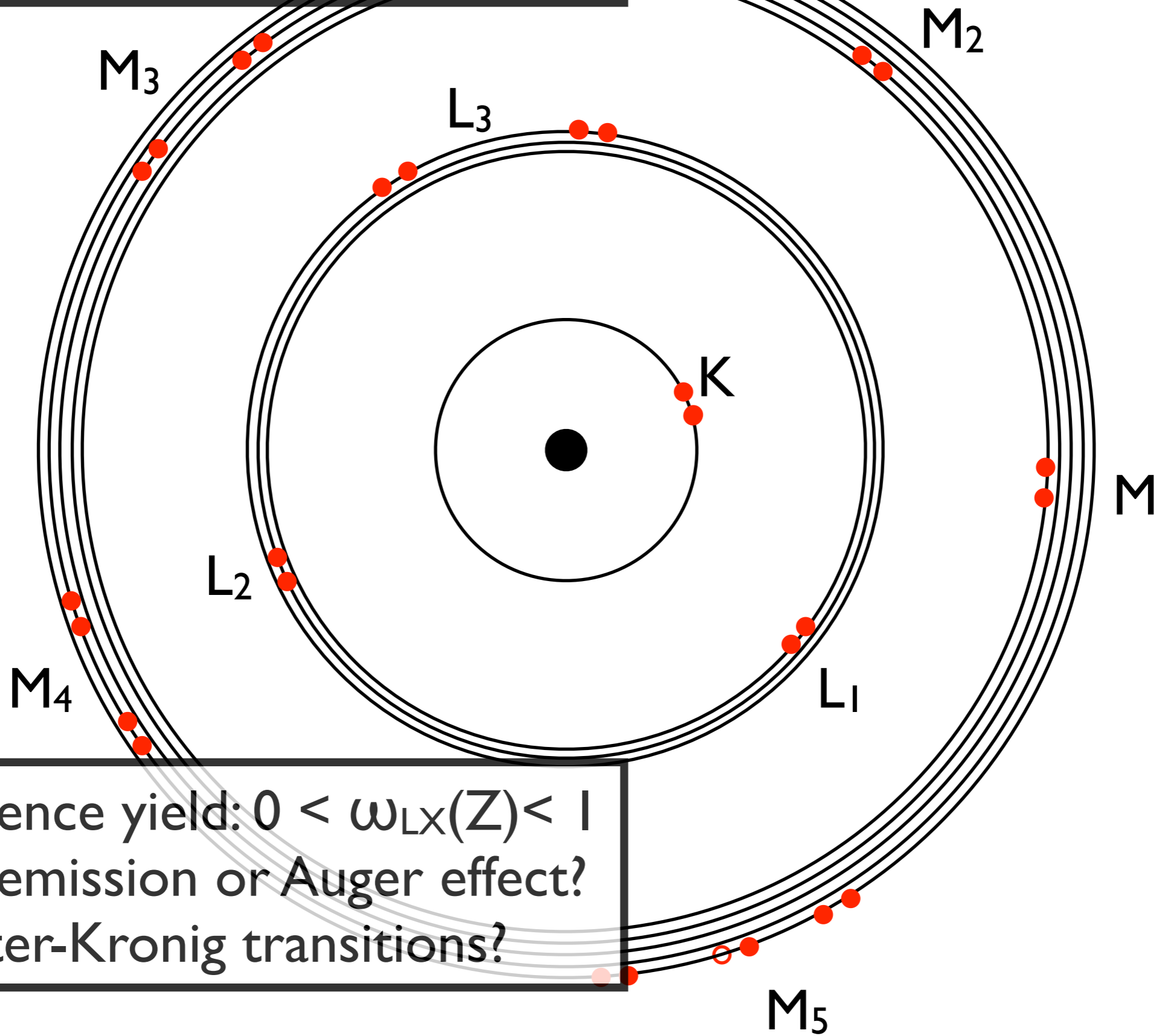
# Photoelectric effect: K shell



Fluorescence yield:  $0 < \omega_{LX}(Z) < 1$   
Photon emission or Auger effect?  
Coster-Kronig transitions?



# Photoelectric effect: K shell



# XRF cross sections: cascade effect

- Occurs whenever multiple shells of a particular element can be excited
- Two components: radiative and non-radiative
- Leads to considerable boost in the observed intensity of L- and M-lines: several times larger than intensity through primary excitations
- Very obvious when using monochromatic excitations
- Very often neglected in quantification and simulations
- Complex implementation
- Many fundamental parameters involved → accuracy?

# New photon coordinates

Photon direction:

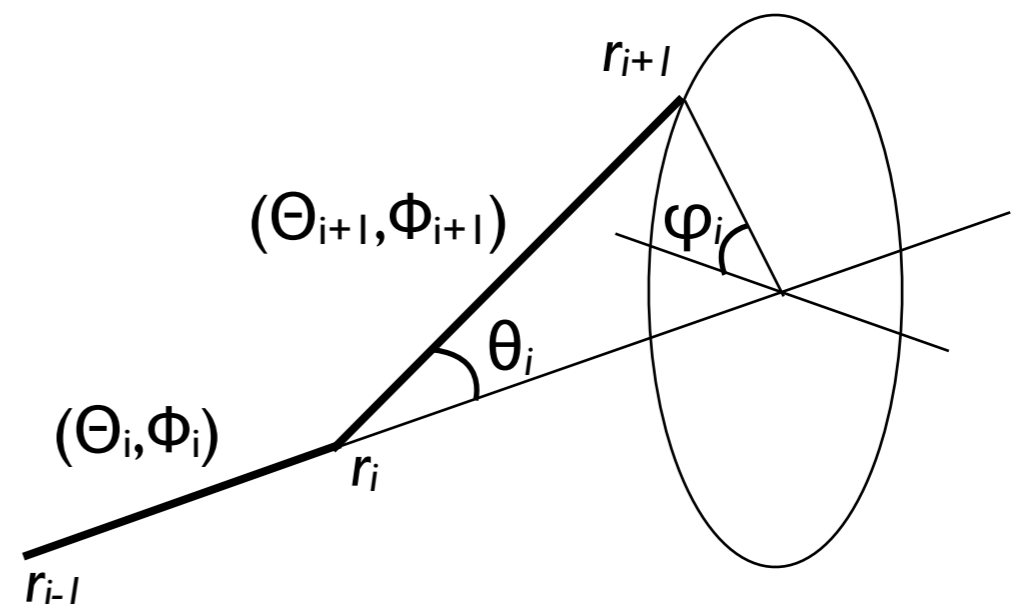
$$\begin{bmatrix} \sin \Theta_{i+1} \cos \Phi_{i+1} \\ \sin \Theta_{i+1} \sin \Phi_{i+1} \\ \cos \Theta_{i+1} \end{bmatrix} = \begin{bmatrix} \cos \Theta_i \cos \Phi_i & -\sin \Phi_i & \sin \Theta_i \cos \Phi_i \\ \cos \Theta_i \sin \Phi_i & \cos \Phi_i & \sin \Theta_i \sin \Phi_i \\ -\sin \Theta_i & 0 & \cos \Theta_i \end{bmatrix} \begin{bmatrix} \sin \theta_i \cos \phi_i \\ \sin \theta_i \sin \phi_i \\ \cos \theta_i \end{bmatrix}$$

Photon coordinates:

$$x_{i+1} = x_i + S_i \sin \Theta_{i+1} \cos \Phi_{i+1}$$

$$y_{i+1} = y_i + S_i \sin \Theta_{i+1} \sin \Phi_{i+1}$$

$$z_{i+1} = z_i + S_i \cos \Theta_{i+1}$$



# Photon termination

- After each interaction, a new step length will be calculated and so on...
- The procedure stops when either the photon is absorbed by the sample or leaves it.
- Upon leaving the sample, a check is performed to determine whether or not the photon hits the detector

# Brute force algorithm: inefficient

- Very large number of photons must be simulated
- Possible loss of photons due to thin, low absorbent samples, low fluorescence yields, and detector geometry
- Usually requires supercomputer

**Code optimizations:  
variance reduction**

# Selection of the step length

- Force photons to stay within the system
- Largest index  $m$  is found according to:

$$\sum_{i=1}^m \mu_i S_i < -\ln(1 - RP_{abs}) \quad \text{with} \quad P_{abs} = 1 - \exp\left(-\sum_{i=1}^n \mu_i S_i\right)$$

- Step length calculated as:

$$s = \sum_{i=1}^m \left(1 - \frac{\mu_i}{\mu_{m+1}}\right) S_i - \frac{1}{\mu_{m+1}} \ln(1 - RP_{abs})$$

- Photon weight multiplied with  $P_{abs}$

# Forced detection

- For each photon at each interaction point
- Calculate the probabilities of all possible *pathways* of the photon to reach a random point on the detector
- Fractional photons added to virtual MCA

$$P = P_{conv} P_{dir} P_{esc}$$



# Fluorescence yield

- Multiply photon weight with fluorescence yield of selected sub-shell
- Avoids the loss of simulated photons to low energy cascade photons
- Cascade effect simulation taken into account by variance reduction through corrected XRF production cross sections

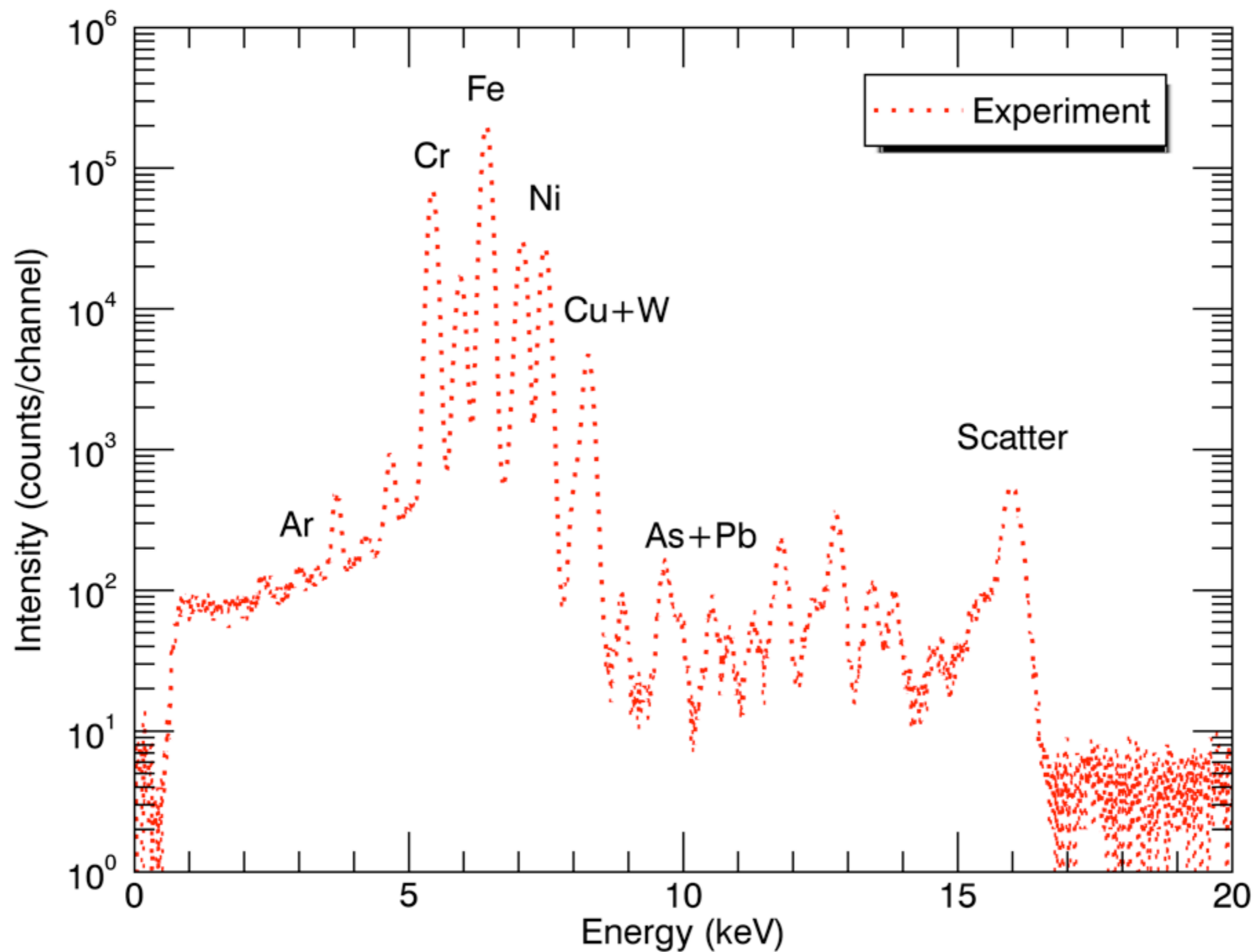
# Detector response function

# Case study: NIST SRM 1155

- Stainless steel Cr18Ni12
- HASYLAB Beamline L
- Excitation energy: 16 keV
- Exposure: 300 s RT
- Degree of polarization  
~ 92 %
- Beam-size: 10 x 10  $\mu\text{m}^2$

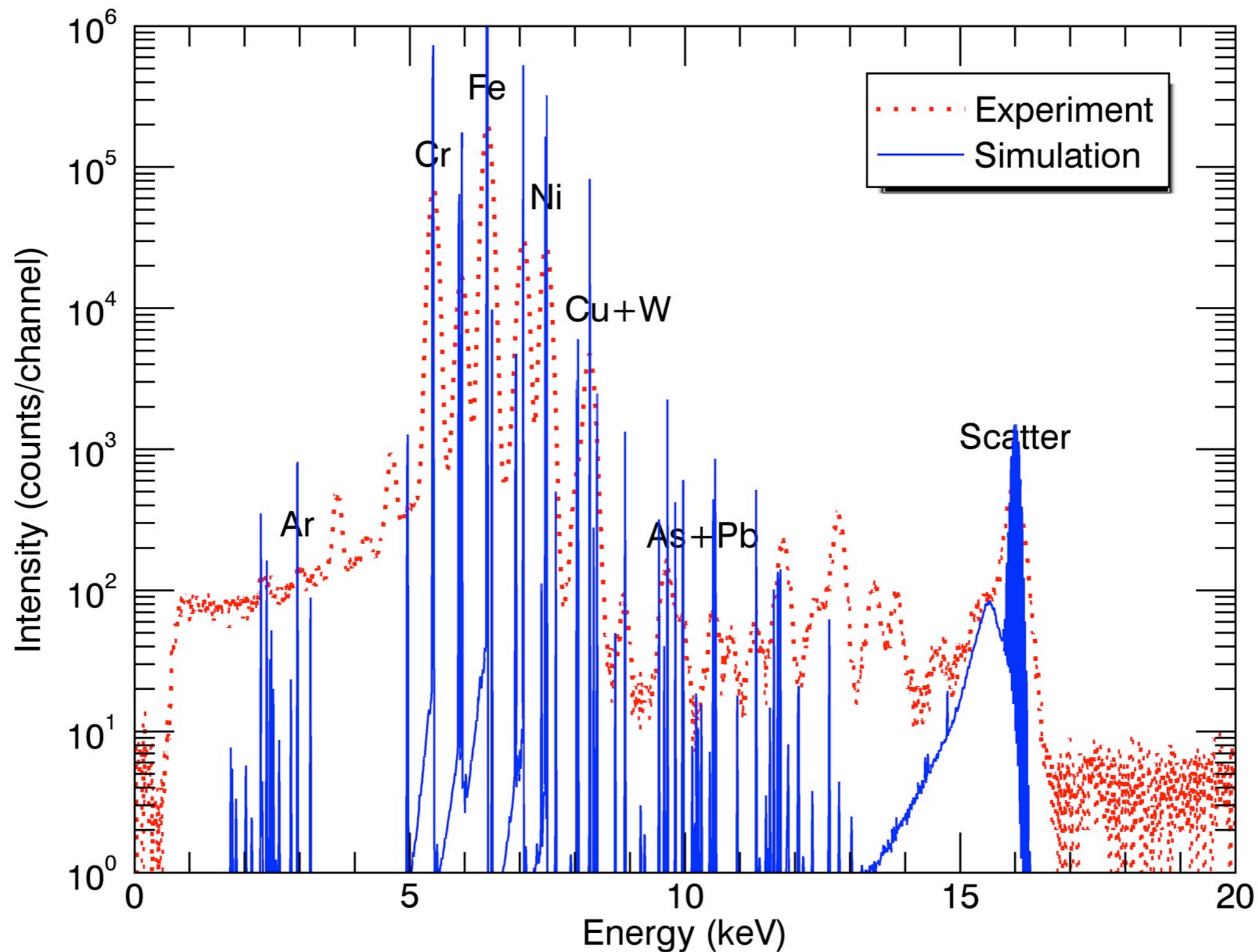
Cr	18.37%
Ni	12.35%
Mo	2.386%
Mn	1.619%
Cu	0.1734%
Co	0.1052%
V	0.0508%
C	0.0445%
S	0.0175%

Stainless steel NIST SRM 1155



**Experimental data**

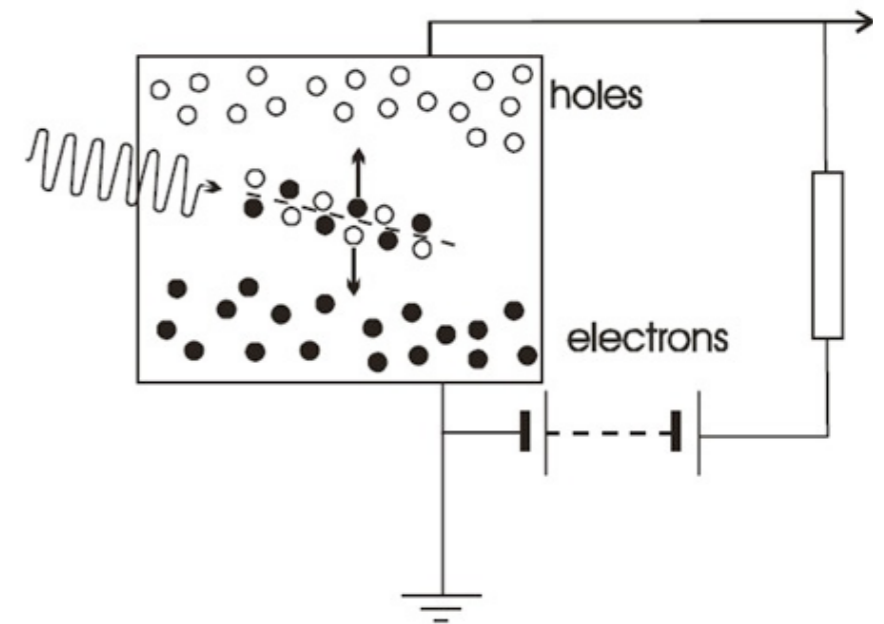
# Stainless steel NIST SRM 1155



# Raw simulation result

# Semiconductor detectors

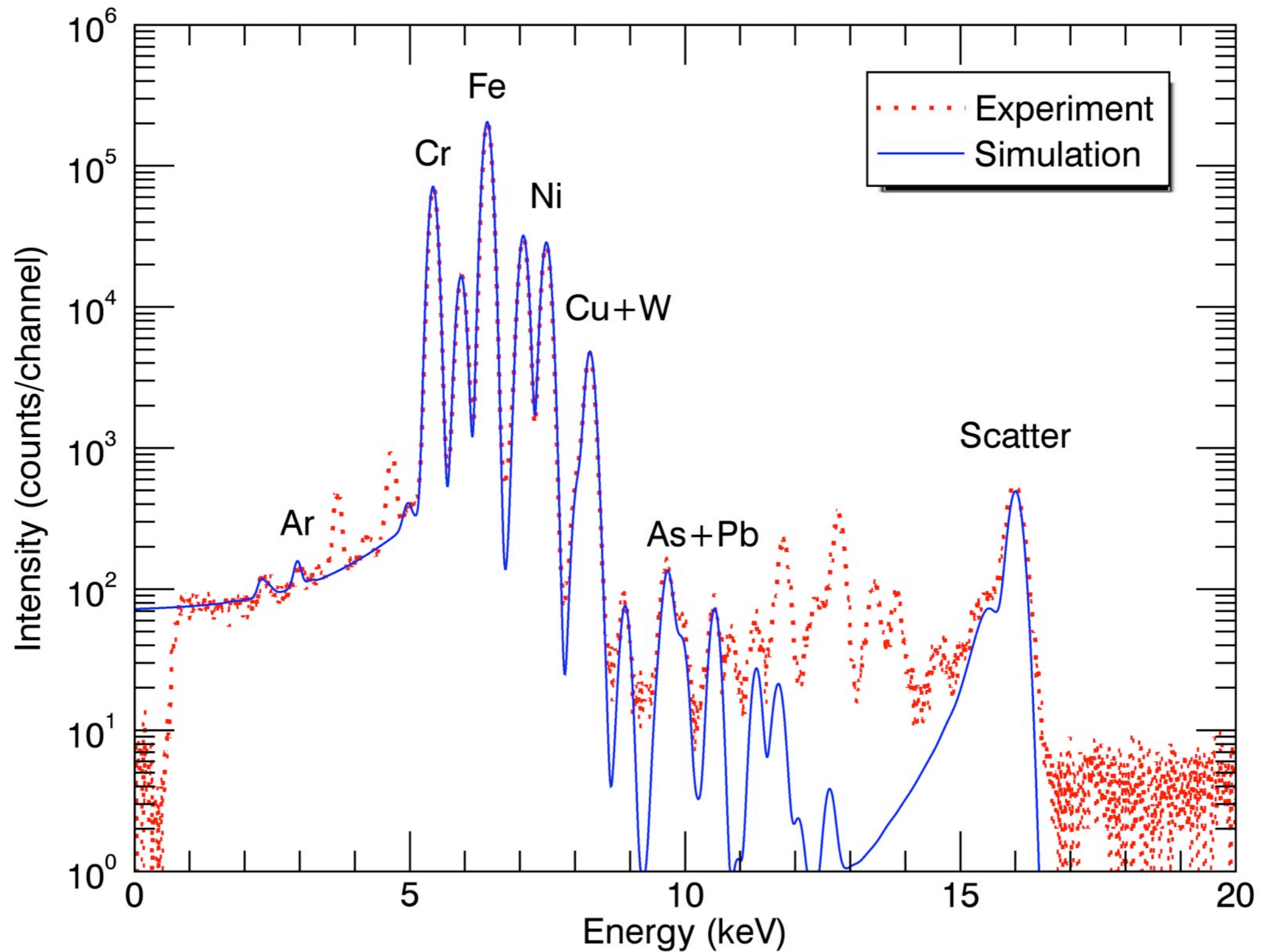
- Incident X-rays will ionize the semiconductor material, leading to the production of electron-hole pairs
- The number of pairs is proportional the energy of the incoming photon
- Influenced by an electric field, the electrons and holes migrate to the electrodes
- Results in a pulse that will be measured in the outer circuit
- Dead time leads to some photons not being counted



# Spectral artifacts: peak broadening

- XRF lines experience Gaussian peak-broadening, due to the statistical nature of the photon-charge conversions and to electronic noise
- Incoming lines are not discrete, but have a Lorentzian profile
- Spectral peaks follow a Voigt profile, a convolution of a Gaussian and a Lorentzian distribution
- Usually approximated as Gaussians or pseudo-Voigt functions

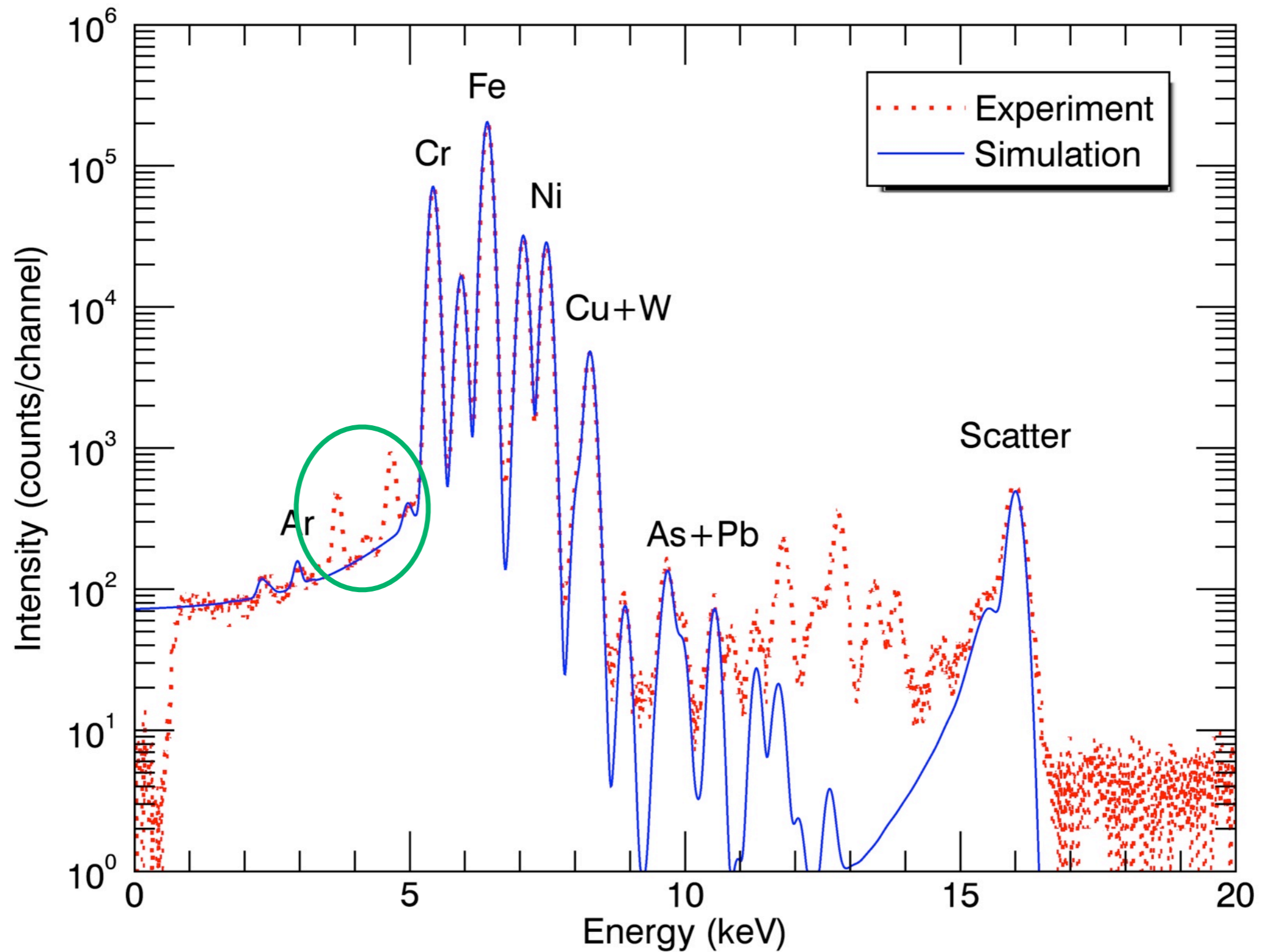
# Stainless steel NIST SRM 1155



# After Gaussian convolution



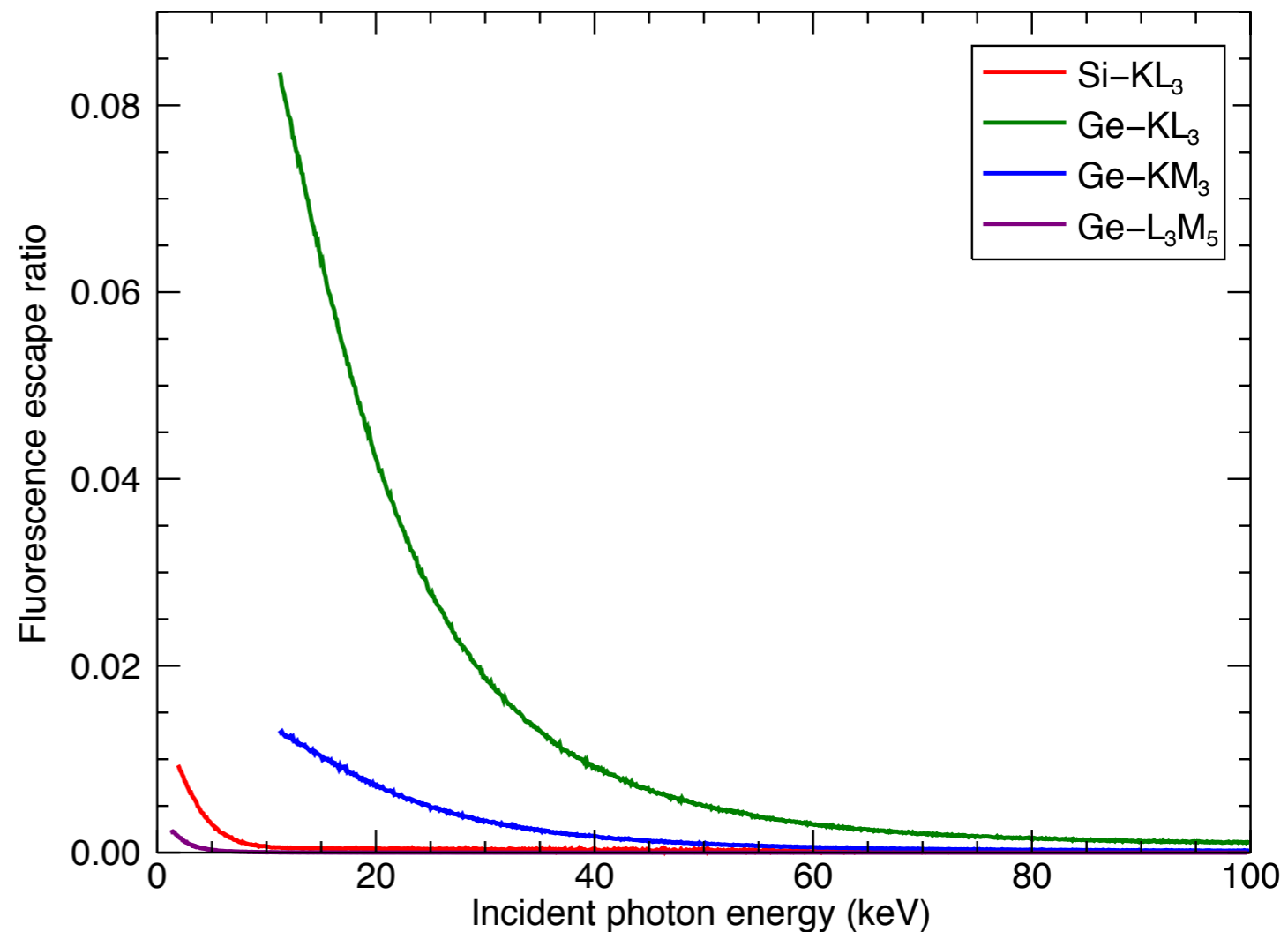
# Stainless steel NIST SRM 1155



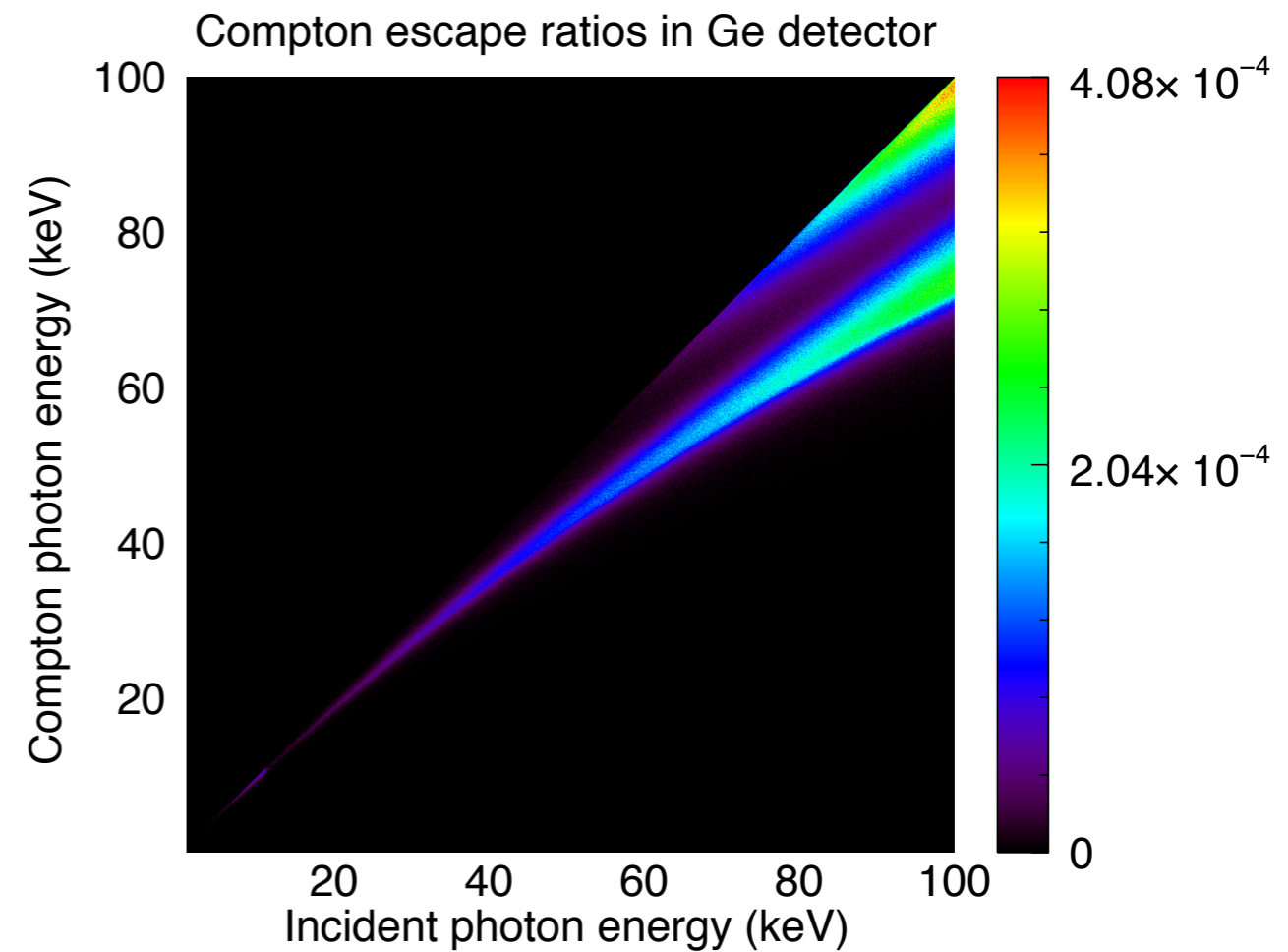
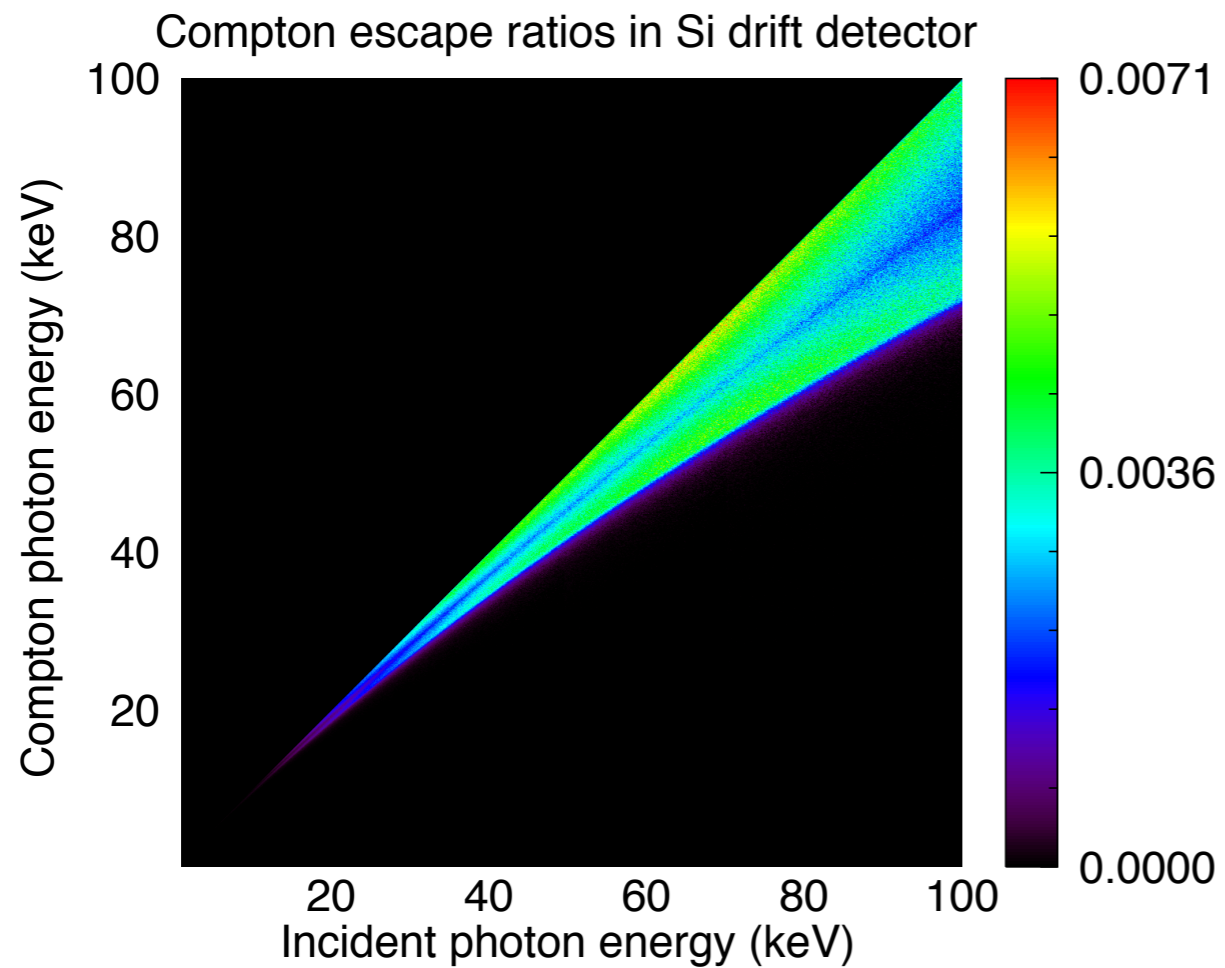
# After Gaussian convolution

# Detector escape peaks

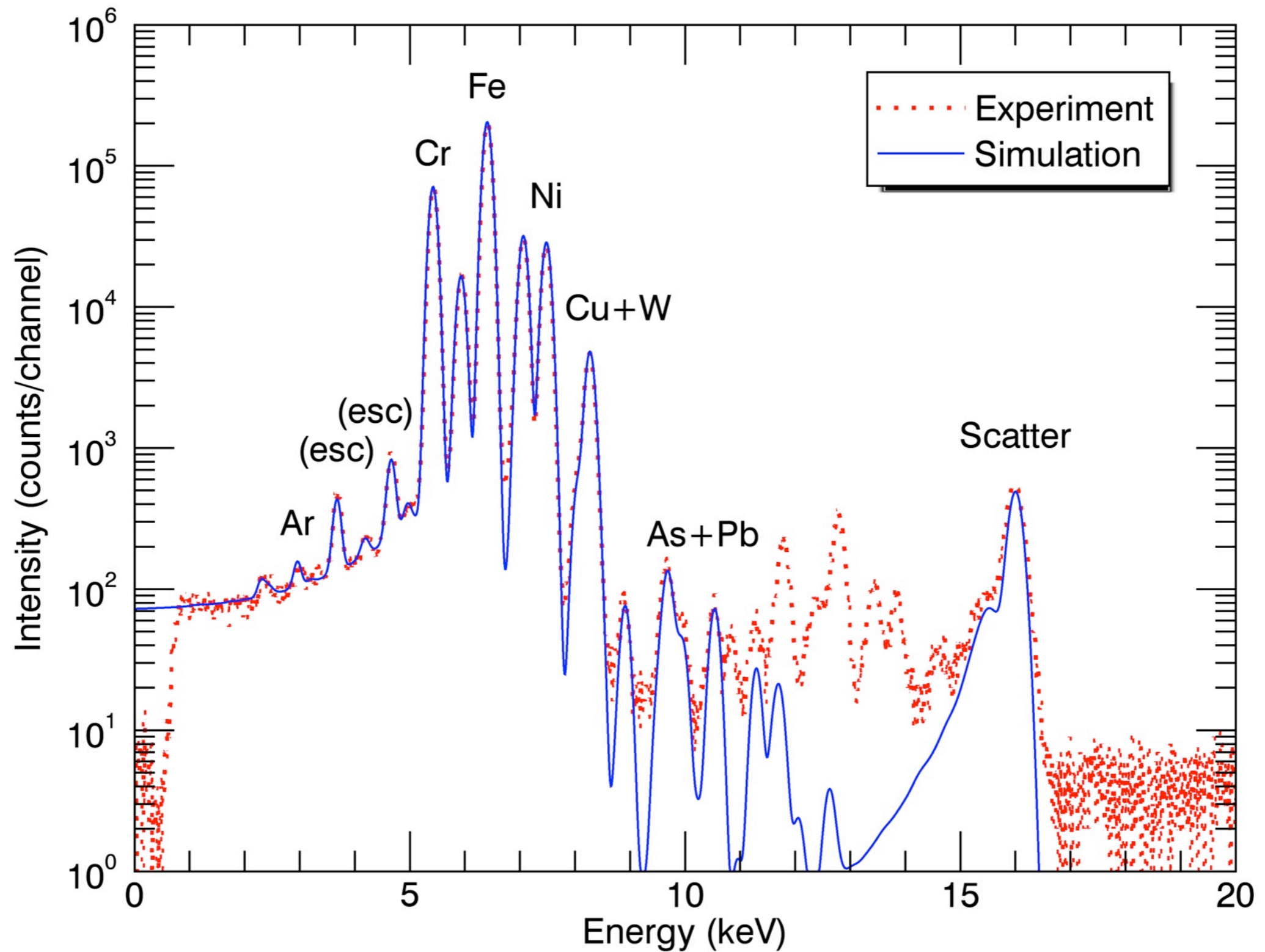
- Photons produced in detector crystal through XRF or Compton scattering may leave detector
- Results in detection of a pulse with energy lower than expected
- Escape peak ratios calculated based on crystal composition and thickness
- Calculated analytically or with Monte Carlo simulation



# Detector escape peaks

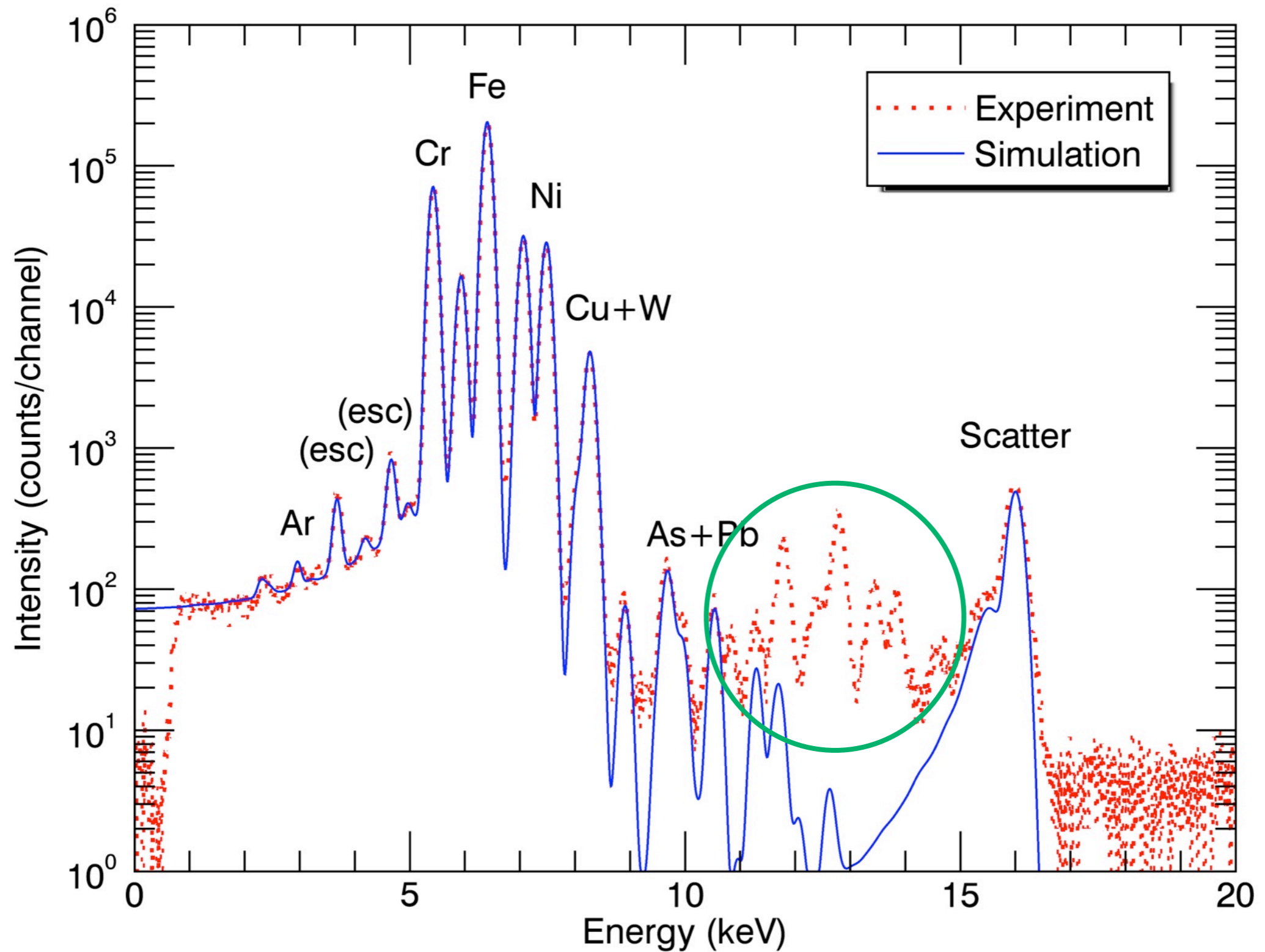


# Stainless steel NIST SRM 1155



# With escape peaks

# Stainless steel NIST SRM 1155

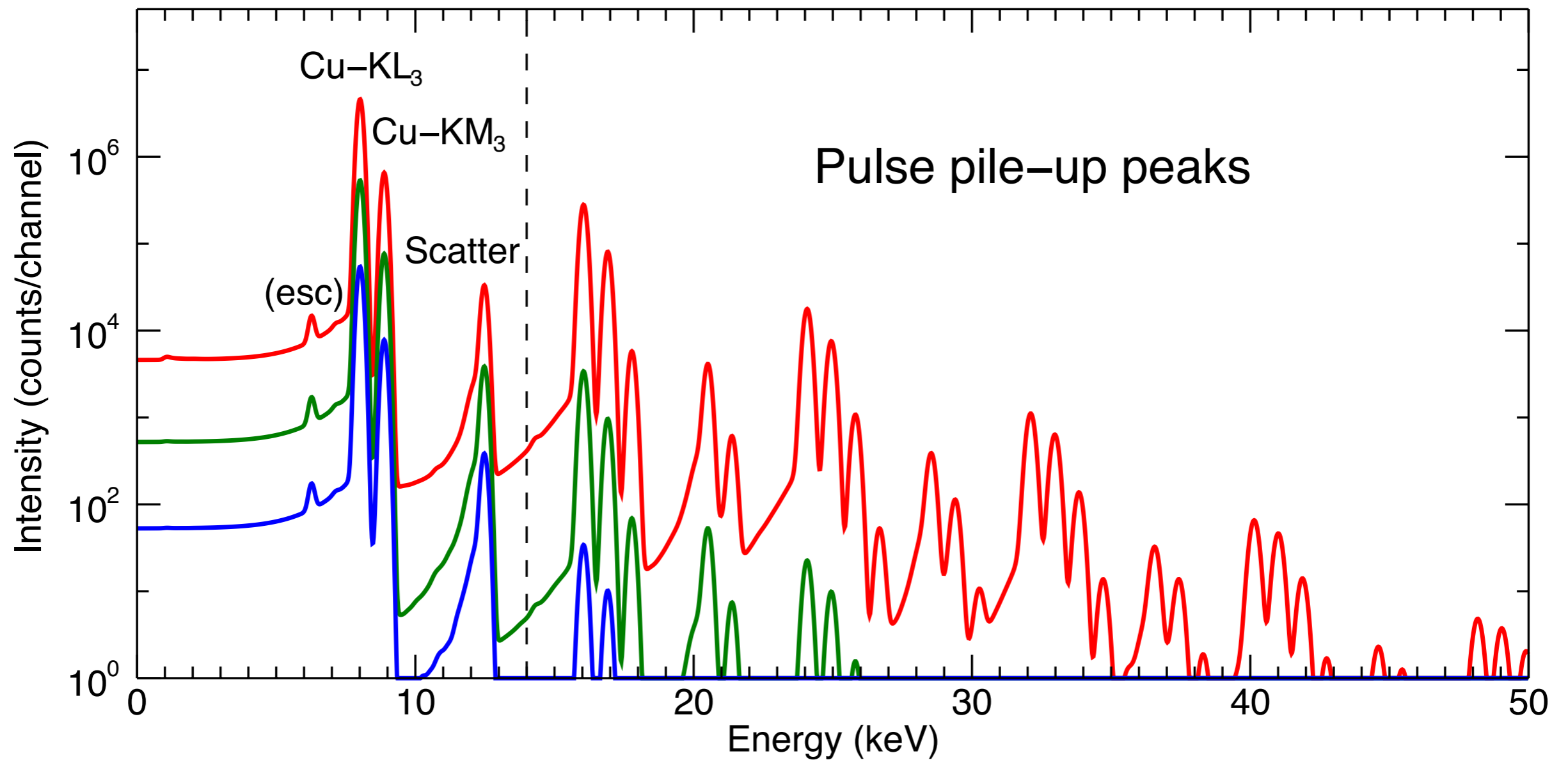


# With escape peaks

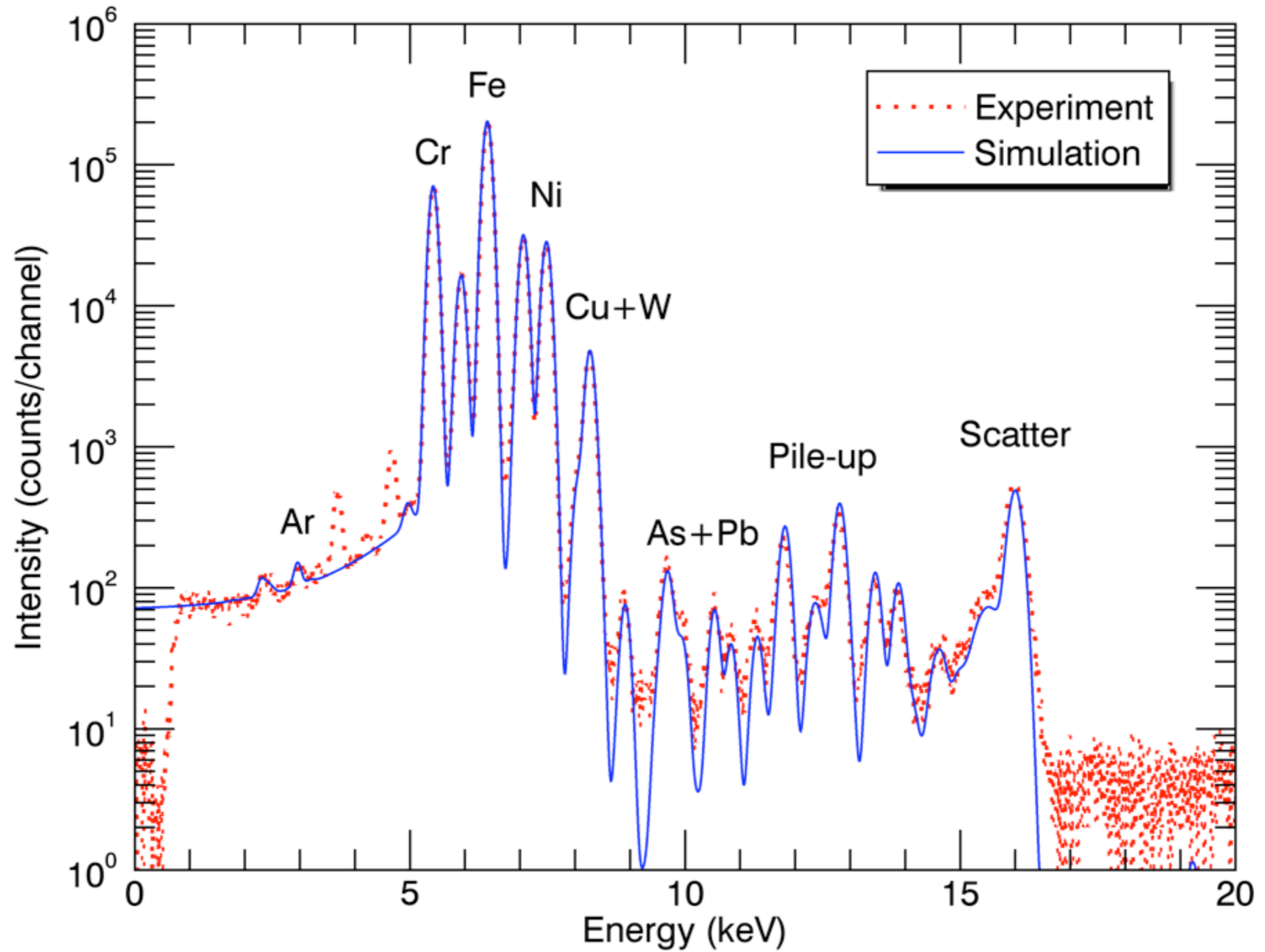
# Detector pulse pile-up simulation

- Emergence of peaks at energy values corresponding to the sum of XRF peaks
- Due to the limitations of the electronics connected to the detector
- Magnitude strongly correlated to beam intensity
- Monte Carlo simulation using exponential pulse interval distribution

# Detector pulse pile-up simulation



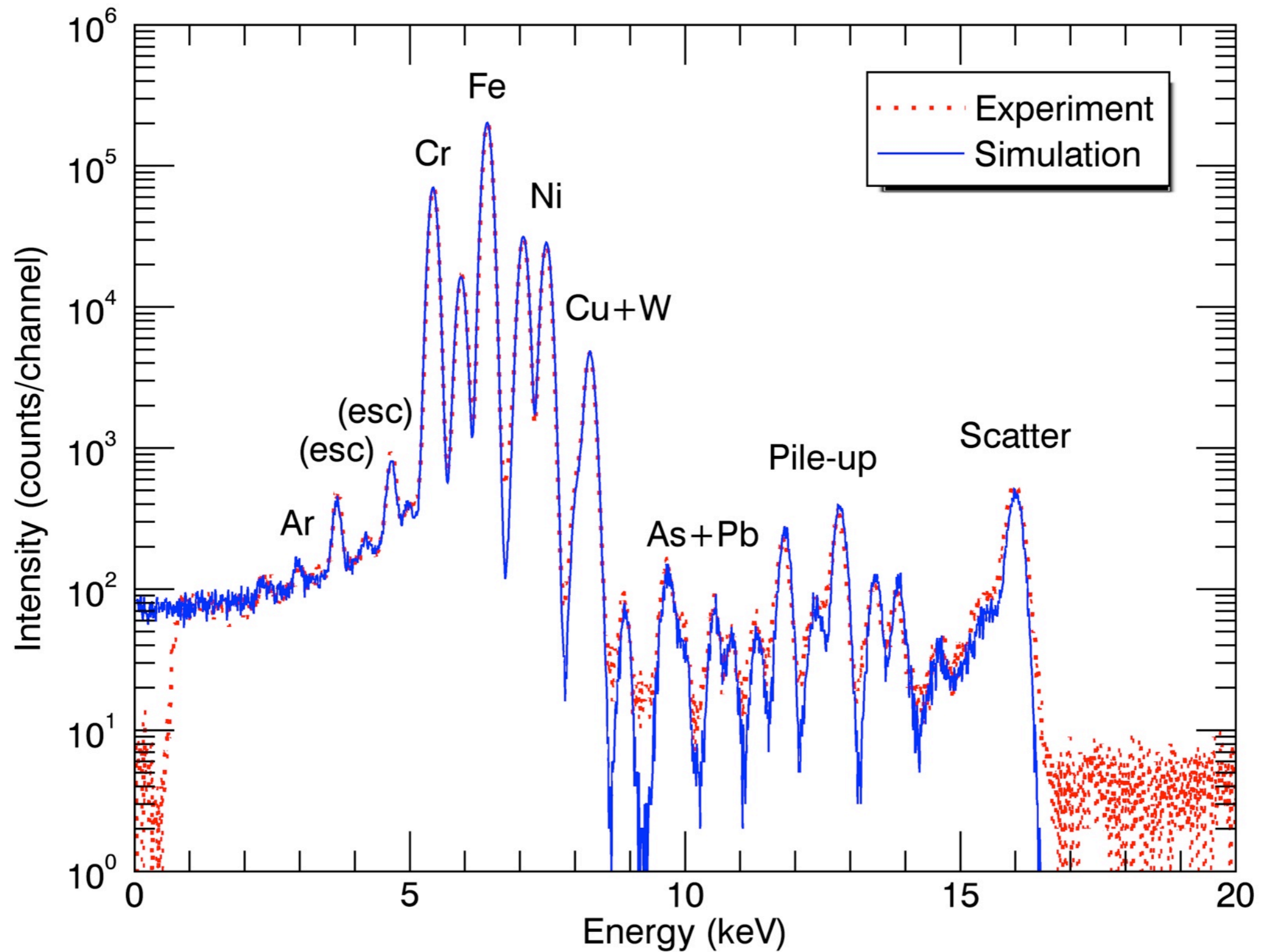
# Stainless steel NIST SRM 1155



# With pulse pile-up...

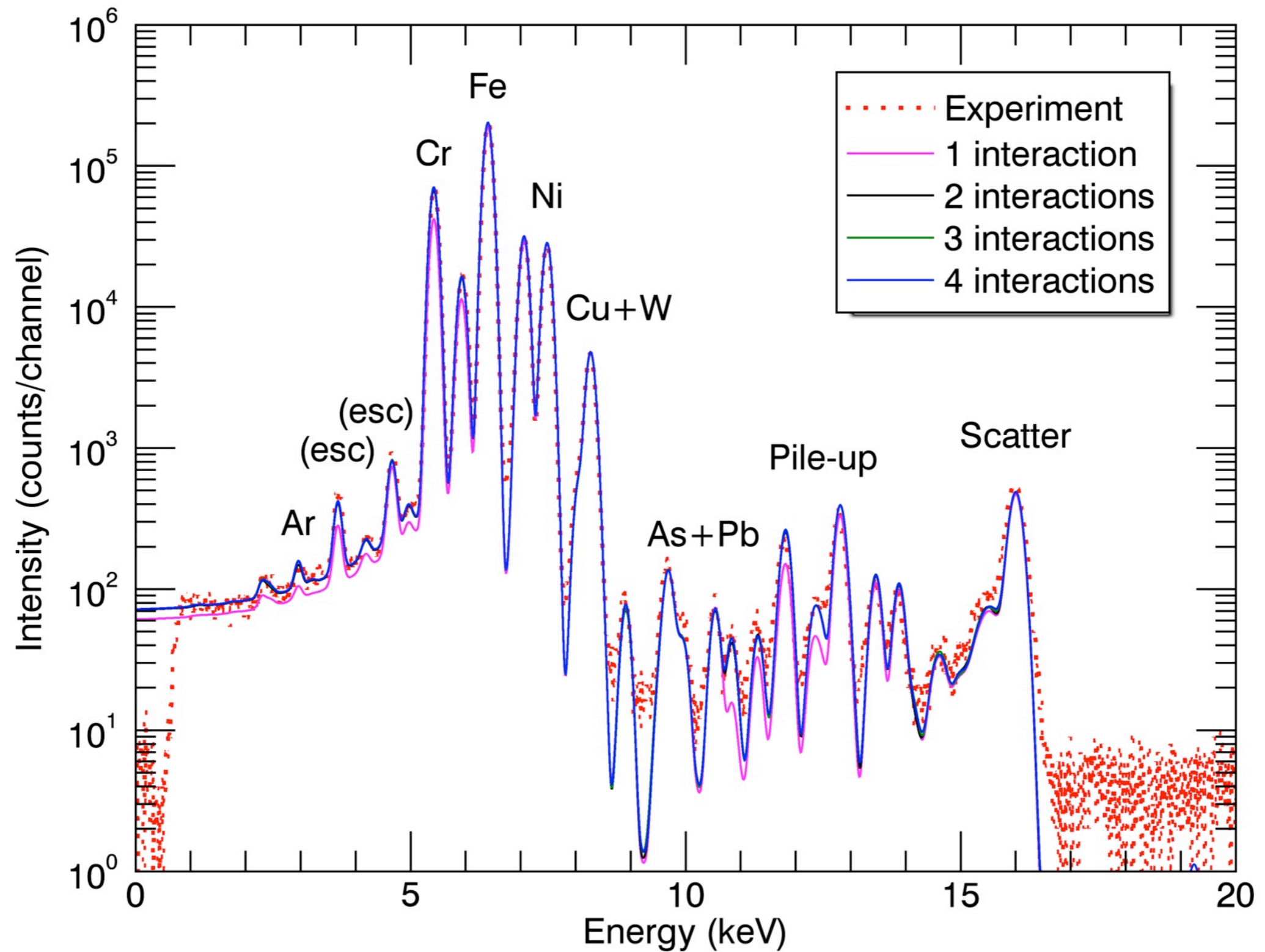


# Stainless steel NIST SRM 1155



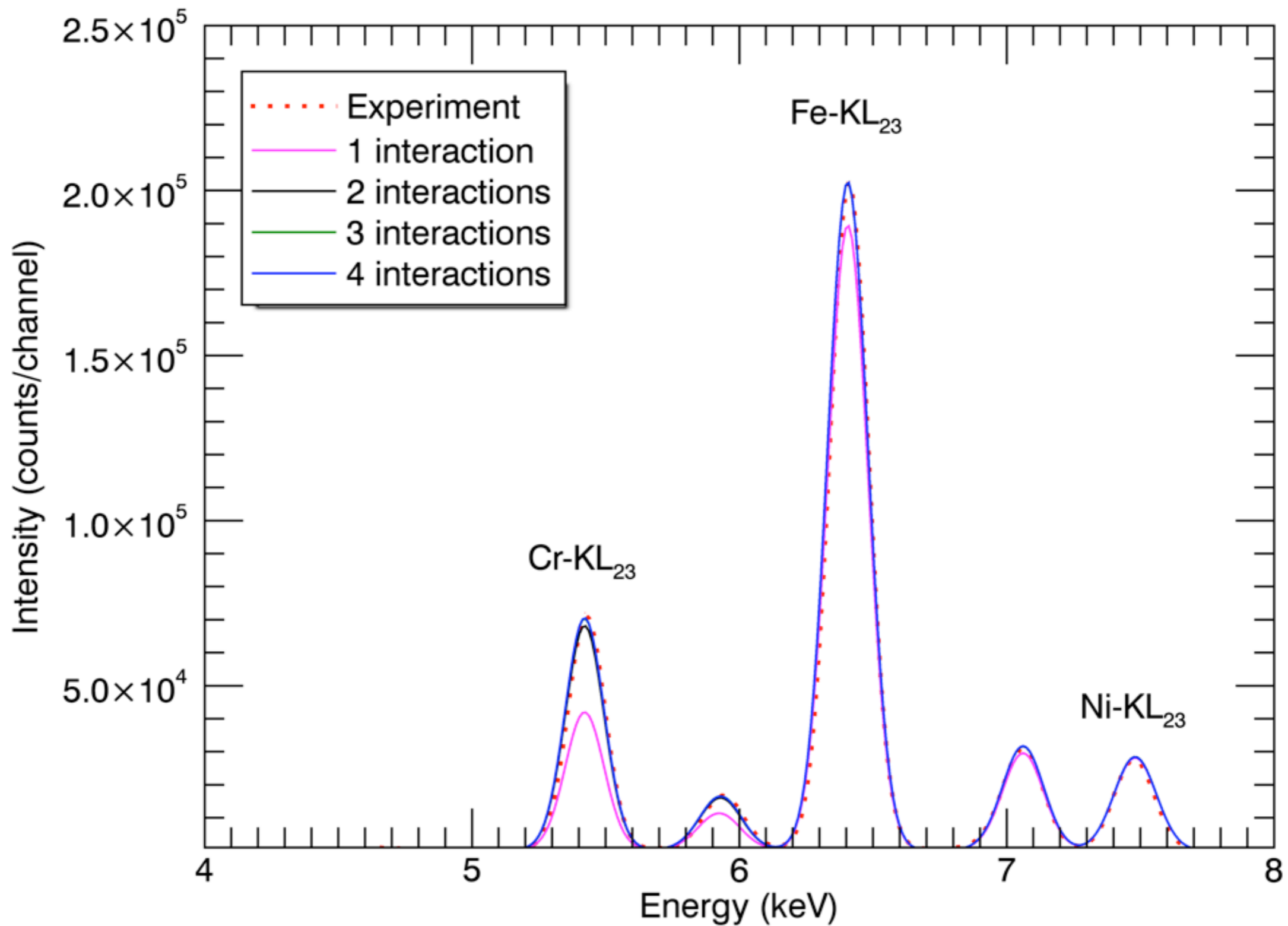
...and some Poisson noise

# Stainless steel NIST SRM 1155



# Higher order interactions

# Stainless steel NIST SRM 1155



# Higher order interactions

# Individual interaction contributions to intensity

- XRF CS of Cr-KL<sub>23</sub>  
@16 keV: 8.3116287  
@Ni-KL<sub>23</sub>: 70.221933  
@Fe-KL<sub>23</sub>: 109.02429!!
- XRF CS of Fe-KL<sub>23</sub>  
@16 keV: 12.699491  
@Ni-KL<sub>23</sub>: 97.242868
- XRF CS of Ni-KL<sub>23</sub>  
@16 keV: 18.460541

Expressed in cm<sup>2</sup>/g

#	Cr-KL <sub>23</sub>	Fe-KL <sub>23</sub>	Ni-KL <sub>23</sub>
1	655007	3084620	482088
2	406554	194120	3066
3	29652	2558	28
4	706	27	< 1

# Overview of available codes

# Geant4

- Low energy electromagnetic package
- Support for cascade effect
- Toolkit, not a finalized program
- Allows for very complex geometries
- Electron-matter interactions
- Open source

# MCSHAPE

- Dedicated XRF code
- Advanced modeling of electrons produced by Compton, Auger and photoelectric effect
- University of Bologna: Jorge Fernandez and Viviana Scot
- Source code not distributed, binaries only

# XRMC

- X-ray spectroscopy and imaging experiments
- Complex sample geometries using quadrics
- Highly extensible
- University of Sassari
- Open source: GPLv3



# References

- L.Vincze et al. *Spectrochim. Acta Part B*, 48(4): 553–573, 1993.
- L.Vincze et al. *Spectrochim. Acta Part B*, 50(2): 127–147, 1995.
- T. Schoonjans et al. *Spectrochim. Acta Part B*, 70:10–23, 2012.

# Acknowledgements

- Laszlo Vincze
- Claudio Ferrero
- Manuel Sanchez del Rio
- Armando Solé
- Geert Silversmit
- Philip Brondeel
- Karen Appel
- Jan Garrevoet
- Beta testers
- Everyone that ever contributed code or reported bugs!

# Acknowledgements

- Laszlo Vincze

- Claudio Ferrero

- Manuel Sá

- Armando Solé

- Geert Silversmit

- Philip Brondeel

- Karen Appel

- Ian Garrevoet

**Thank you!** ~s

- Everyone that ever contributed code or reported bugs!